# Tactile Sensing in Human-Computer Interfaces: The Inclusion of Pressure Sensitivity as a Third Dimension of User Input

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# Abstract

This paper presents a review of tactile technologies for human-computer interactivity via touch interfaces, where touch force is measured as a third dimension of user input along with touch location. Until recently, tactile technologies for computing applications have detected only the location of a touch (or several touches simultaneously) with no additional information about the force or pressure the user imparts to the interface. Such additional input may open up new applications in force-enhanced gestures, for example the touch force may dictate the linewidth used in drawing software, or the speed of a scroll gesture may be increased with increasing applied force. Here we review the underlying physical principles behind several force sensitive touch technologies. The latest innovations by leading technology developers, only available in the patent literature, are also described and where public data exists the force-resistance behaviours of several key technologies are compared in terms of their sensitivity and range of response. The advantages and disadvantages of each technology are discussed, along with the current and possible future applications in consumer electronics. It is shown that the concept of pressure–sensitivity as an additional user input mechanism is fast gaining traction, with many implementations already found in commercial products. Furthermore, a study of the patent trends shows that this functionality may soon become commonplace in the new generation of consumer electronic devices.

Keywords: Tactile sensing, Human-computer interactions, Touchscreen technology

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# 1 1. Introduction

Tactile sensing has become increasingly important in human-computer interac-3 tions (HCI), introducing novel and intuitive ways for the user to interact with a 4 computer interface, such as in machinery control panels, point-of-information (POI) 5 and point-of-sales (POS) kiosks, and device interfaces in consumer electronics. Touch 6 may be detected on an integrated trackpad (such as in a laptop) or on a transparent 7 touchscreen overlaid onto the display (for example in smartphones and tablets), thus 8 eliminating the need for a separate touch interface as the user can directly interact q with the icons shown on the underlying display. 10

Currently most touch interfaces can detect only the location of the touch, i.e. 11 the device knows if and where it is being touched, but with no information about 12 the force of the touch. However recent advances have begun to incorporate force or 13 pressure sensitivity as a third dimension of user control. The pressure sensitive com-14 ponent may be incorporated directly into the touch location sensor. Alternatively, 15 the pressure sensing component may take the form of force sensors external to the 16 location sensing interface. This includes force sensors which are placed underneath 17 the corners of the interface or force sensors found in an external device such as a 18 pressure-sensitive stylus. The addition of pressure-sensitivity opens up new methods 19 of interactivity, including pressure based text entry, menu selection and handwrit-20 ing/signature recognition [1, 2, 3], and force enhanced gestures for scrolling, zooming 21 and image manipulation [4, 5]. 22

Force or pressure–sensitive tactile sensors can already be found in applications 23 such as robotics and electronic skin [6, 7], and in biomedical applications such as bite 24 force measurement in dentistry and human gait analysis [8, 9]. Here, tactile sensing 25 may be defined as the "detection and measurement of contact parameters in a prede-26 termined contact area and subsequent pre-processing of the signals at the taxel level, 27 i.e., before sending tactile data to higher levels for perceptual interpretation" [10]. 28 These applications have been the topic of many review articles which describe the 29 latest research and innovation [11, 12, 13, 14]. 30

Whilst there exist several reviews on the underlying technologies for location sensing in touch interfaces [15, 16, 17, 18, 19, 20] and advances in multi-touch and 3D gesturing [21, 22], to date there is no review in the literature which discusses the inclusion of pressure sensitivity into touch interfaces. The aim of this review paper is to draw together the various methods of adding pressure sensitivity to touch interfaces in HCI applications via specialised tactile sensors. First, we present a short introduction to the various methods of pressure sensing used for tactile applications,

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along with the advantages and disadvantages of each. Then the applications of these 38 sensors in HCI touch interfaces are discussed in detail. The technologies have been 39 broadly split according to application, including keyboards, laptop trackpads, and 40 transparent touchscreens. For the latter, a distinction is made between resistive and 41 capacitive technologies. Together, these account for 80% of the total revenue and 42 95% of all touchscreen units shipped in 2011 [15] and most pressure-sensing solutions 43 are focussed here. However, the inclusion of pressure-sensing in other touchscreen 44 technologies is also briefly discussed. A distinction is also made between pressure-45 sensing solutions which are incorporated directly into the touch module of the device 46 (e.g. continuous thin films or 2D matrix arrays of sensors incorporated into the 47 touchscreen structure) and a small number of discrete sensors placed outside of the 48 touch module (e.g. four force sensors placed underneath the display). 49

# <sup>50</sup> 2. Pressure Sensing Mechanisms

Sensor	Modulated Physical Pa- rameter	Operating Principle	Manufacture Details	Advantages	Disadvantages
Strain Gauge	Resistance	Applied pressure causes change in length and cross-sectional area of conductive coil	Can be micro-machined and embedded into a polymer to create a thick film sensor array with mechanical flexibility	Well established design and manufacture processes Easily integrated into existing circuitry High spatial resolution achievable for micro-machined strain gauges	Response scales with surface area – can be large in the lateral dimension Insensitive to lateral force Sensitive to temperature fluctuation and humidity Less sensitive than piezoresistive sensors Non-linearity and hysteresis of response
Piezoresistive	Resistance	Applied pressure changes inter-atomic spacing such that electrons are promoted or demoted from conduction band	Can be micro-machined and embedded into polymer to cre- ate a sensor with mechanical flexibility	Well established design and manufacture processes High sensitivity, especially to low applied pressure Smaller lateral dimension than strain gauge High spatial resolution achievable for micro-machined piezoresistors	Piezoresistive material can be brittle and fragile Relatively costly materials When embedded into polymer there can be a loss in sensitivity
Conducting Polymer Composite	Resistance	Applied pressure deforms the composite resulting in more conduction pathways between filler particles	Can be printed by screen- printing or similar	Simple fabrication techniques mean low cost for large area fabrication Mechanically flexible and robust structure Low power consumption due to high resistance of off- state	Conduction is isotropic – can lead to low spatial res- olution Hysteresis effects due to mechanical properties of polymer causes poor repeatability of response Typically have a low dynamic range
Intrinsically Conductive Polymer	Resistance	Applied pressure deforms the polymer causing current flow between adjacent polymer chains	Can be printed by screen- printing or roll-to-roll	Mechanically flexible and robust structure Low-cost large-area fabrication	Typically low sensitivity Conduction is isotropic - can lead to low spatial res- olution
Piezoelectric	Voltage	Applied pressure causes redis- tribution of internal charge and produces a voltage	Can be printed by screen- printing or roll-to-roll	High sensitivity Mechanically flexible and robust structure	Cannot detect a dynamic force Requires amplifier to boost output signal Cross-talk between piezo- and pyroelectric effects Cross-talk between sensor elements in array
Capacitive	Capacitance	Applied pressure decreases the electrode separation and in- creases the mutual capacitance between the electrodes	Complex fabrication tech- niques, e.g. photolithography and thin-film deposition to produce complex 3D structure	High sensitivity Not affected by temperature variations Small sensor size leads to high spatial resolution	Sensitive to electromagnetic interference leading to poor signal to noise ratio Requires relatively complex circuitry with high power consumption Cross-talk between sensor elements in an array
Inductive	Magnetic inductance lead- ing to a change in voltage	Applied pressure causes dis- placement of a magnetic core through a primary coil, induc- ing a voltage which is measured by secondary coil	Typically bulky, mechanical structure not suited for thick or thin film deposition techniques	High sensitivity and dynamic range High repeatability of response with little or no hys- teresis	Bulky structure such that arrayed sensors would pro- vide low spatial resolution Possible frictional losses between magnetic core and coil
Optical	Light intensity	Applied pressure deforms opti- cal fibre and decreases the light intensity measured at CCD de- tector	Sensors may be produced by embedding optical fibres in a polymer	No cross-talk between sensors Insensitive to external electromagnetic noise Can be flexible and durable when embedded into poly- mer	Hysteresis effects due to mechanical properties of polymer leading to poor repeatability of response Signal can be attenuated by initial misalignment of the sensor leading to false-touch effects.

 $Table \ 1: \\ {\rm Comparison \ of \ pressure-sensitive \ tactile \ technologies}$ 

The most commonly used tactile or touch pressure sensors are based on resistive, capacitive, piezoelectric, inductive and optical sensing. Each of these techniques has advantages and disadvantages which are summarised in Table 1. Further information on tactile sensors can be found elsewhere in the literature, for example Yousef *et al* give an excellent review of tactile sensor arrays for robotics applications, detailing the spatial resolutions of each sensor array discussed [13].

57 2.1. Resistive Pressure Sensors

# 58 2.1.1. Strain Gauges and Piezoresistors

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<sup>60</sup> A piezoresistor exhibits a change in electrical resistance with applied stress. This <sup>61</sup> type of response is seen in semiconducting materials including germanium and silicon <sup>62</sup> (polycrystalline or amorphous). When a stress is applied to a semiconductor resistor <sup>63</sup> with initial resistance R, the change in resistance  $\Delta R$  is given by

$$\Delta R = R(\pi_l \rho_l + \pi_t \rho_t) \tag{1}$$

where  $\pi$  is the piezoresistive coefficient and  $\rho$  is the applied stress along the longitudinal and transverse directions, denoted by the subscripts l and t respectively. The piezoresistive coefficient is related to the change in the inter-atomic spacing when a stress is applied to the material, making it easier or harder for electrons to be promoted into the conduction band.

Piezoresistivity may also be observed in metals, although the piezoresistive coef-69 ficient is often much smaller than that of semiconductor materials. Here, the effect 70 is mostly due to the change in geometry of a conductor under applied stress which 71 affects the current flow through the material. Strain gauges use this effect to detect 72 applied pressure. They have long winding conductive coils so that when the sensor is 73 deformed through an applied pressure the cross section of the coil decreases and the 74 conduction length increases, thus decreasing the resistance through the coil. Strain 75 gauges typically have a higher sensitivity than piezoresistors. However piezoresistors 76 are capable of giving a higher output per unit area and are typically smaller in the 77 lateral dimension. 78

<sup>79</sup> Both piezoresistors and strain gauges can be embedded into an elastomeric poly-<sup>80</sup> mer which provides mechanical flexibility. However the response of the sensor can <sup>81</sup> then become prone to creep and hysteresis effects, especially for piezoresistive sensors.

#### <sup>82</sup> 2.1.2. Conducting Polymer Composites

Conductive polymer composites comprise electrically conductive filler particles dispersed into an insulating polymer matrix. The conductivity of the composite is



Figure 1: A network of conducting filler particles is dispersed in an insulating polymer matrix at a loading close to the percolation threshold and deposited between two electrodes. Compression of the composite increases the number of conductive pathways throughout the composite.

strongly dependent on the filler volume fraction and the nature of conduction be-85 tween individual particles. At a low loading the particles are well dispersed and 86 there are very few conductive pathways through the composite, leading to high re-87 sistance. At the critical particle loading (the percolation threshold) the conductivity 88 increases as a greater number of conductive pathways are formed. This is described 89 by percolation theory or effective medium models. At loadings close to the perco-90 lation threshold the resistance becomes very sensitive to deformation. A pressure 91 sensor may be realised by fabricating a conducting polymer composite such that in 92 its natural undeformed state the filler content is close to the percolation threshold. 93 Then when the composite is deformed the spacing between filler particles decreases 94 producing a large increase in the conductivity of the composite. This mechanism is 95 represented in Fig.1. The sensors are naturally flexible and are usually robust with 96 a simple and well-established manufacture process. However, the response may be 97 prone to hysteresis effects and typically has a low sensing range. Some conductive 98 polymer composites have been fabricated to exhibit a large dynamic range in re-99 sponse to pressure. In this case there is a high loading of conductive particles which 100 have a rough surface texture which is completely wetted by the polymer. Conduction 101 is via a pressure-induced quantum tunnelling conduction mechanism [23, 24, 25]. 102

### 103 2.1.3. Conductive Polymers

For intrinsically conductive polymers, the flow of electrons is through the con-104 jugated backbone of the polymer which has either p-type or n-type doping. Com-105 pression of the polymer allows charge to transfer between adjacent polymer chains. 106 Examples of intrinsically conductive polymers include polyaniline, polypyrrole and 107 polyacetylene. Their use as a flexible pressure sensor has been well researched, for 108 example see [26, 27] and in many cases they can be deposited using a screen-printing 109 or roll-to-roll printing process [28]. Whilst their mechanical flexibility makes them 110 robust sensors, in their basic form they are inelastic and typically exhibit a low 111 sensitivity to applied pressure. 112

#### 113 2.2. Capacitive Pressure Sensors

The capacitance change between a fixed electrode and a deformable electrode, separated by an air gap or other dielectric medium, may be used to detect an applied force. The capacitance between two plates of area A separated by distance d by a medium with permittivity  $\varepsilon_r$  is given by

$$C = \varepsilon_0 \varepsilon_r \frac{A}{d}.$$
 (2)

Hence, a change in the spacing between electrodes, for example caused by a force 118 applied to the upper electrode, can result in a measurable change in capacitance. It 119 is also possible to use a spacer layer whose dielectric properties change with applied 120 force. Capacitive sensors show high sensitivity even at low applied forces and they 121 are insensitive to temperature variations. Sensor arrays can be printed onto flexible 122 thin films, for example, Pritchard et al demonstrate an array of capacitive sensors 123 with 150 nm thick gold electrodes and a  $1.5 \,\mu\text{m}$  thick Parylene C dielectric layer [29]. 124 Substrate dependent, the sensors can be very thin and the sensor arrays are capable 125 of giving a high spatial resolution. However complex circuits are often required to 126 address and read-out from each capacitive sensor in the array and there is a problem 127 of cross-talk between nearby sensors. The sensors also have a high sensitivity to 128 external electromagnetic interference. 129

#### 130 2.3. Piezoelectric Pressure Sensors

Piezoelectric materials undergo a change in the surface charge density with the application of stress, due to either the formation or realignment of induced dipoles within the material. When the piezoelectric material is placed between two electrodes, a voltage can be measured where the amplitude is directly proportional to the stress applied and to the piezoelectric coefficient. Pyroelectric materials generate a voltage due to changing temperature. When thermal energy is absorbed



Figure 2: (a) Molecular arrangement inside a P(VDF-TrFE) nanocrystal, where black circles represent carbon atoms, grey circles represent fluorine atoms and white circles represent hydrogen atoms. The distribution of electrical charge produces a permanent dipole moment. (b) Thin polymer film containing nanocrystals of P(VDF-TrFE). Electrical poling results in the alignment of the nanocrystal dipoles along the direction of the applied electric field. Compression of the film will cause a change in dipole orientation, inducing an electrical signal.

the material expands or contracts, again changing the surface charge density. The 137 ferroelectric polymer polyvinylidene fluoride (PVDF) exhibits both a large piezoelec-138 tric and pyroelectric responses and can be printed to form a transducer or pressure 139 sensor device [30, 31, 32]. The copolymer P(VDF-TrFE) (polyvinylidene fluoride-tri-140 fluoroethylene) is often used as it has a greater crystallinity after annealing. The 141 structure of P(VDF-TrFE) is shown in Fig.2(a). The alignment of hydrogen and flu-142 orine atoms give the structure a permanent electric dipole moment. Fig.2(b) shows 143 a thin film composed of P(VDF-TrFE) nanocrystals, where the dipoles have been 144 aligned through the application of an electric field double that of the coercive field 145 strength (a process called poling). Upon compression of the film by an applied force, 146 the orientation of the dipoles is altered and an electrical signal is induced. 147

Once touched, the induced voltage discharges over a short time-scale through the 148 internal resistance of the PVDF layer, and this is a large problem for the detection of 149 static forces. This technology is therefore unsuitable for the detection of a constant 150 force. There can also be a problem of cross-talk between adjacent sensors in an array. 151 However the voltage output can be large even for small deformations due to the high 152 sensitivity of the piezoelectric material, and the sensor elements do not require a 153 power supply. They can be printed, or otherwise deposited, onto flexible substrates 154 making them well suited for flexible applications. 155

# 156 2.4. Inductance Pressure Sensors

A primary conductive coil induces a magnetic field which is then sensed in a 157 secondary sensing coil. This principle is used in the linear variable differential trans-158 former (LVDT), where displacement of a magnetic core through the primary coil 159 changes the induced voltage measured in the sensing coil. This voltage is directly 160 proportional to the length of core magnetically coupled to the sensing coil. The LVDT 161 is primarily used as a displacement sensor. Displacing the magnetic core changes the 162 coupling length between core and coil and produces a measurable change in the 163 amplitude and phase of the voltage in the sensing coils. The displacement of the 164 magnetic core can also be linked to the force applied to it so that this type of sen-165 sor is also suitable for force or pressure measurement. The sensitivity and dynamic 166 range of these sensors are typically very high, however they can be quite bulky so 167 that a sensor array may give a low spatial resolution. However, they show virtually 168 no hysteresis effects and have a high repeatability. 169

#### 170 2.5. Optical Sensors

A basic optical pressure sensor consists of an LED light source and a CCD detector 171 separated by a length of optical fibre. When a force is applied to sensor, the optical 172 fibres bend and the light received at the CCD is attenuated. It is possible to embed 173 a mesh of optical fibres into an elastomer to produce a flexible pressure sensitive 174 sensor [33]. Optical sensors are insensitive to electromagnetic noise and suffer no 175 cross-talk effects between adjacent sensors. They can be robust and flexible when 176 embedded into a polymer matrix. However initial bending or misalignment of the 177 sensor may produce unwanted signal attenuation and false-touch effects. 178

# <sup>179</sup> 3. Sensor Requirements and Considerations for Applications in HCI Touch <sup>180</sup> Interfaces

A force sensor may be defined as giving a constant reading as a function of applied 181 force irrespective of the contact area. A pressure sensor will give, with a constant 182 applied force, a reading which is inversely proportional to the area of applied force. 183 Most sensors described in this review are a combination of both, where the sensor 184 output depends on both the applied force and the contact area. However, the term 185 'force sensitive' is often used in the literature and especially in the patents when 186 describing these devices. The devices are not always true force sensors and are not 187 designed to measure exact levels of applied force. Rather, the device is designed 188 to detect varying *levels* of applied force. The software can then execute a specific 189 response depending on the force level detected, such as a light touch or a hard press. 190

For the purpose of HCI touch interfaces a light touch may be of the order of 0.1 N and a hard press up to 10 N. This force may be detected indirectly through:

- An increase in contact area between electrodes, associated with applying a force to a specific area of the device (purely a surface effect)
- Deformation of one electrode relative to the other causing either
- Compression of a piezoresistive layer deposited between the electrodes,
   and therefore producing a change in resistance through the sensor
- Straining of a piezoelectric layer deposited between the electrodes, and
   measuring a change in voltage across the sensor
- A change in capacitance between the two electrodes resulting from the
   change in spacing between them
- A combination of the above.

Of course, in real-world applications force is applied via a human fingertip or 203 a stylus over a finite area. For the former, the area over which the force applies 204 depends upon the force itself – as a human fingertip is compliant by nature and the 205 harder the press the larger the touch area. It is often assumed this contact area 206 remains constant, and testing of the touch interfaces usually involves a probe of 207 fixed dimension. The area over which the force applied is important, especially for 208 touchscreens which rely on deformation of the upper electrode. For the same value 209 of force, a larger area upon which the force acts will result in a smaller maximum 210 deflection than if the force is applied over a smaller area. Hence only a measure of the 211 pressure will allow direct comparison between technologies for which the dimensions 212 of the testing probe are different. However, in many cases (especially for those in the 213 patent literature) this level of detail is not provided. Often in the patents the applied 214 force is quoted in units of mass. Here we have approximated 10 g as equal to 0.1215 N force for purposes of simplification. Throughout this review, the term pressure-216 sensitive is used to describe touch interfaces capable of detecting applied levels of 217 force over a fixed contact area as described above. Where the dimensions of the 218 test probe are identical, the response is quoted in units of force. For comparison 219 of different technologies for which the available data is collected using probes of 220 different dimensions, whenever possible the response is quoted in terms of pressure. 221 If there is no data on contact area, the force is used instead with the caveat that 222 direct comparison is difficult. 223



Figure 3: Projected mutual capacitive touchscreen. The approach of a conductive object such as a finger detracts from the charge stored between two fixed electrodes, resulting in a change in capacitance. For a matrix array of electrodes, each electrode intersection is capable of measuring a change in capacitance and hence a touch event.

The specific requirements for each sensor are strongly dependent on the intended 224 application and how the input pressure is intended to be used. For example, in a 225 keyboard the input pressure may be measured underneath each key and may define 226 whether the output is an upper or lower case letter. Here, a distinction need only be 227 made between a light touch and a hard press. For touchscreens overlaid on top of a 228 display (either LCD or OLED), or for a trackpad of a laptop or similar, it may be 229 advantageous to differentiate many different levels of pressure. Here, such detailed 230 pressure information may be beneficial, for example for controlling brush stroke size 231 in drawing software. 232

# 233 4. Applications of Pressure Sensors in HCI Touch Interfaces

#### 234 4.1. Capacitive Touchscreens

#### 235 4.1.1. Projected Capacitive Touchscreens

Projected capacitive (P-Cap) touchscreens work by measuring a change in ca-236 pacitance associated with the increasing proximity of a finger to the touch interface. 237 (Note that this is an entirely different principle to capacitive pressure sensors as 238 described in Section 2.2 which detect pressure by the change in separation of two 239 conductive electrodes). In self-capacitive systems, the capacitance of the human 240 body acts to increase the self-capacitance of a single electrode. For mutual capaci-241 tive systems, the approaching finger detracts from the charge stored between a pair 242 of electrodes and reduces the capacitance between the electrodes, as shown in Fig.3. 243

The transparent electrodes, usually Indium doped Tin Oxide (ITO), are printed in a matrix pattern such as rectilinear rows and columns or interlocking diamonds. Each electrode intersection is scanned individually, allowing every touch to be registered.

Capacitive touchscreens (specifically P-Cap) are currently the market leader for 247 consumer electronics applications. With the release of the Apple iPhone in 2007, 248 capacitive technology became mainstream and is now the standard for touchscreens 249 in consumer electronics. Surface capacitive touchscreens are also available but are less 250 common. Further information on all types of capacitive touchscreens can be found in 251 the literature [15, 16, 17]. P-Cap touchscreens can only detect input from a human 252 finger or conductive stylus and are highly sensitive to electronic noise. Performance is 253 hindered by surface moisture or other screen contaminants. Because each electrode 254 intersection is scanned using a high sampling rate the power consumption is high 255 compared to resistive touch screens. However, they currently have higher spatial 256 resolution than resistive touchscreens, require a very low activation force and are 257 more durable due to their rigid design. These benefits have led to the dominance of 258 P-Cap in touch interfaces for smartphones, tablets and trackpads. 259

Previous attempts to measure applied pressure in P-Cap touchscreens associated 260 the size of the contact area with the force applied, as a harder press will result in a 261 greater contact area between finger and screen due to the compliant nature of the 262 human fingertip. A larger contact area means that more electrode intersections are 263 triggered and by integration of the capacitance values recorded at each intersection 264 the contact area can be calculated and the applied pressure can be estimated. This 265 approach has been demonstrated in [34, 35]. A difference in contact area may 266 also be used to differentiate between adult and child input and to adjust the device 267 functionality accordingly [36]. However, one potential issue is that this approach 268 requires additional calibration to compensate for variation in user finger sizes and 269 has limited accuracy. For example, without user calibration the method cannot 270 distinguish between a hard press from a small finger and a light touch from a large 271 finger. It is difficult to detect anything beyond a moderately hard press, beyond 272 which the touch area does not increase significantly. 273

#### 274 4.1.2. In-Cell 'Pressed' Capacitive Touchscreens

In-cell touch refers to the internalisation of the touch sensors inside an LCD pixel array. As such, this technology is currently only found in the established LCD display industry and is not currently available for the newer OLED displays. Typically the sensor is integrated into the thin film transistor (TFT) array, the colour filter layer, or both. This should eliminate the need for further cover sheets or coatings on top of the LCD display. The benefit is that both the touch interface and the display are



Figure 4: Pressed capacitive in-cell touch interface. The touch electrodes are incorporated into the LCD display and are deposited on the thin film transistor (TFT) substrate and the colour filter (CF) substrate. When the top surface of the LCD is pressed the colour filter substrate deforms, reducing the distance between the two electrodes and causing an increase in the mutual capacitance.

<sup>281</sup> made as one manufacture process.

There are three main in-cell touch technologies; capacitive, voltage and light sensing, full details of which can be found elsewhere [37]. To the author's knowledge pressure–sensitivity has not yet been incorporated into in–cell voltage or light sensing technologies.

In-cell capacitive sensing has had the most success in terms of total research and 286 commercial products, and can be further categorised as pressed, self, or mutual ca-287 pacitive depending on the operating principles. The principles for the self and mutual 288 capacitive are the same as for the P-Cap technology described earlier. However in 289 the case of in-cell technology the touch electrodes are incorporated into the display 290 module instead of being manufactured entirely separately from the display, allowing 291 for thinner, lighter devices. Mutual in-cell P-Cap touchscreens, developed by LG 292 Display for Apple, Inc. can be found in the iPhone 5 and iPhone 6 models. However, 293 just like for P-Cap technology, internalising the detection of applied pressure is not 294 currently possible. 295

'Pressed' capacitive in-cell touch sensing elements consist of two electrodes: a 296 sensor spacer is incorporated onto the colour filter glass, and a flat electrode is 297 deposited onto the TFT layer, underneath the liquid crystal array of the LCD. Often 298 there is a further column spacer to prevent full contact between the two electrodes. 299 as demonstrated in Fig.4. This uses the sensing principle described in Section 2.2. 300 When a force is applied to the upper surface of the LCD, the colour filter glass 301 deforms, causing the spacing between the electrodes to decrease and/or the dielectric 302 constant of the liquid crystal material to change. Then, by Equation 2, a change 303



Figure 5: Capacitance output as a function of applied pressure, using data taken from [38, 40].

in the mutual capacitance between the two electrodes may be measured. In this 304 way both touch location and touch force can be measured. Note that although the 305 mutual capacitance is measured, this is very different to the mutual P-Cap technology 306 described earlier. The electrode configuration is different, and in this case the mutual 307 capacitance is changed by a physical force rather than the approach of a conductive 308 object which 'steals' charge from the electrodes, as is the case for P-Cap. The touch 309 resolution depends on the number of display pixels per touch sensor (and therefore 310 the total number of touch sensors present in the entire display). This is typically in 311 the range of 4:1 (high touch resolution) to 16:1 (lower touch resolution). 312

Because of the relation between the deformation (electrode separation) and the 313 capacitance, this technology seems a promising candidate for the detection of pres-314 sure. Research has been conducted which investigates the change in capacitance with 315 applied force. H. Kim et al designed and fabricated a 20x20 array of pressed capaci-316 tive touch sensors [38, 39]. Indium Zinc Oxide (IZO) electrodes were deposited onto 317 flexible polycarbonate films. On the lower electrode an insulating layer of the poly-318 mer SU-8 was deposited at a thickness of 5  $\mu$ m. The two electrodes were separated 319 using spacer columns of SU-8, creating a void space 8  $\mu$ m in height between the two 320 electrodes. The insulator and spacer layer was formed from the polymer SU-8. The 321 total thickness of the sensor array was 253  $\mu$ m and an average optical transmittance 322

of 86 % in the visible light range (380–770 nm) was measured. A force gauge with a 323 contact area of  $1 \text{ mm} \times 1 \text{ mm}$  was used to apply force up to 0.8 N. The data, taken 324 from [38], is replicated in Fig.5 which shows the measured capacitance as a function 325 of the applied pressure on the touchscreen. It can be seen that the capacitance in-326 creases linearly from an initial value of 0.9 pF at zero pressure to around 4.5 pF at 327 an applied pressure of  $0.1 \text{ Nmm}^{-2}$ . After this the capacitance value saturates. Nu-328 merical simulation confirmed that a force of 70 mN applied over 1 mm<sup>2</sup> was required 320 to deflect the top electrode by 8  $\mu$ m. At this maximum deflection the electrodes are 330 in contact and there will be no further increase in the capacitance. Whilst this result 331 demonstrates the principle of pressure sensing via pressed capacitive touch sensors, 332 this particular sensor is only capable of differentiating applied force up to around 333 0.1 N and cannot differentiate anything beyond a light touch (0.1 N). Therefore, the 334 pressure sensing capabilities are very limited. 335

K. Kim et al designed a similar sensor array using single wall carbon nanotube 336 (SWCNT) electrodes separated by a compressive silicone gel [40]. The cross-array of 337 electrodes were formed by scribing and patterning of SWCNT coated PET substrates. 338 The electrode separation (silicone thickness) was approximately 500  $\mu$ m. The optical 339 transmittance was 81 % measured at a wavelength of 550 nm. The touchscreen was 340 tested at forces from 0 to 5 N using a probe with diameter of 8 mm. The pressure-341 capacitance response, using data replicated from [40], is shown in Fig.5. It can be 342 seen that the capacitance increases from and initial value of 1.92 pF at zero applied 343 pressure to 3.42 pF at a pressure of  $3.5 \text{ Nmm}^{-2}$ . It is clear that the magnitude of the 344 electrode separation plays an important role in determining the range of forces the 345 touchscreen is sensitive to. When contact area is taken into account (as the same 346 force, applied over a larger area will result in a smaller vertical displacement than for 347 a force applied over a smaller area) a greater saturation force may be achieved using 348 a greater electrode separation. However in practice a large electrode separation is 349 disadvantageous, as it adds significantly to the overall thickness of the touchscreen. 350 For devices such as smartphones and tablets, slimness is often prioritised. 351

One potential problem with the pressed-capacitive approach is that the electrode 352 spacing, and therefore capacitance change, tends to be very small and the signal 353 to noise ratio (SNR) is low. This is especially true for low applied forces. Noise is 354 introduced by capacitive coupling between the force sensing and the display circuitry 355 and is also inherent within the LCD. Often, more complicated circuitry is required 356 to boost the signal and reduce the noise in the system. A research group affiliated 357 to Sharp Laboratories have developed one method of overcoming the problem of 358 poor SNR [41]. A high sensitivity active pixel sensor (APS) circuit is used along 359 with in-pixel signal amplification. The circuitry of the force sensors and LCD are 360

kept separate by using a series of bumps on the upper deformable electrode. The 361 conductive coating on these bumps is electrically separate from the pixel electrodes. 362 On the bottom electrode, a guard ring is etched around the sensor capacitor structure 363 to electrically isolate the liquid crystal material in the force sensing region from the 364 display pixel region. This reduces the electrical noise and allows in-pixel amplification 365 of the sensor signal. Whilst there is no information regarding the thickness of the 366 sensor build, the output voltage (calculated from the change in capacitance) is found 367 to increase for applied forces between 0 and 2.5 N. The sensitivity of the response 368 can be further modified by variations in the APS circuitry. C. Kim et al have also 369 designed a similar device using active matrix circuitry [42]. In this case, the electrode 370 gap is just 0.5  $\mu$ m. However, only forces up to 0.2 N have been investigated using 371 a 0.8 mm test probe diameter. The complex circuitry can often lead to a high 372 power demand in these devices. Huang et al have counteracted this by using an 373 algorithm which rectifies the non-linear relationship between applied force and output 374 capacitance [43]. The touchscreen prototype by Chen et al can measure both normal 375 and shear forces using an offset electrode pattern [44]. 376

Despite the advances in read-out circuitry and enhanced SNR, a fundamental 377 problem of pressed in-cell capacitive sensors for touchscreen technologies is the poor 378 durability. Because the device is reliant on deformation of the color filter glass layer, 379 there can be no protective cover glass on the top surface of the device. A cover glass 380 layer is vital in high-end applications such as smartphones and tablets, to protect the 381 LCD display from damage. Cover glass is just not compatible with pressed in-cell 382 technology, as a greater activation force would be required to produce any response, 383 making the device insensitive to light touches. Because of the greater stiffness of a 384 thick cover glass layer, the area of deflection becomes larger for a given force resulting 385 in greater error in the measured touch location. Furthermore, applying pressure to 386 an LCD display can cause image artefacts which can last even after the finger is 387 removed from the screen. 388

Several key technology companies, including Synaptics and Apple Inc., have 389 patent applications which describe the incorporation of a pressed capacitive layer 390 into a touchscreen [45, 46, 47]. In this format there are usually three sets of elec-391 trodes, where the lower two define a p-cap location sensor and the third is printed 392 onto a deformable substrate which lies at the top of the electrode stack. The capac-393 itance change between these electrodes and the uppermost in the p-cap sensor array 394 can be used to quantify the applied force. However, to the author's knowledge this 395 type of touchscreen can at present only be found in the Samsung ST550 and TL220 396 cameras. Here, the user is advised not to use sharp objects on the screen, and is 397 further warned about the potential of discolouration of the LCD screen if the screen 398



Figure 6: Four-wire resistive touchscreen. Two transparent electrodes are separated by an array of spacer dots. Touch by any object causes the upper electrode to deform and contact the lower electrode. The resistance of the electrode material acts as a voltage divider, where the ratio of the measured voltages give the location of the touch. In this format, only a single touch can be detected at any one time.

is pressed too hard [48]. The pressure sensitivity of this kind of touchscreen is notutilised at all in the camera.

# 401 4.2. Resistive Touchscreens

Resistive touch sensing was first commercialised by Elographics, Inc. in 1971, 402 with a transparent touchscreen produced in 1977. A four-wire resistive touchscreen 403 is shown in Fig.6. Two substrates, one of which must be sufficiently flexible, are 404 coated with a transparent conductor such as ITO to form the electrodes. These 405 are separated by an air gap created by small spacer dots (for example insulating 406 glass beads) which prevent initial contact. When the user presses onto the flexible 407 substrate, the two electrodes make electrical contact and a voltage is measured. The 408 resistance of the ITO acts as a voltage divider, so that the ratio of voltages measured 409 can be used to determine the position of the touch. In the four-wire format only 410 a single touch may be detected at any one time. However, in 2005 JazzMutant 411 (renamed Stantum in 2007) developed multi-touch resistive touchscreens using their 412 patented Interpolated Voltage Sensing Matrix (iVSM) [49]. Here, the top and bottom 413 electrodes are deposited in rows and columns, with each intersection forming a square 414 with sides of 1.5 mm. Each square acts as a digital switch, with a current flowing 415 when top and bottom electrodes make contact. 416

The input for a resistive touchscreen can be applied by a finger or any other (non-sharp) object, whether conductive or insulating. They have a lower power consumption than capacitive-style touchscreens as current only flows in the active

on-state, and they are also cheaper per unit area. However, the main disadvantages 420 are that only a single touch can be detected (in the 4-wire configuration) and the 421 durability is poor, as ITO printed onto a flexible substrate is known to crack and 422 flake when flexed [50]. A high activation force is also required that depends on the 423 mechanical flexibility of the upper electrode and the depth of the air gap. Current 424 applications for resistive touchscreens are usually in the commercial and industrial 425 markets, for example retail point-of-sales and point-of-information kiosks, automo-426 tive and industrial touch controls. 427

For transparent touchscreens, it is possible to print a pressure-sensitive layer 428 directly onto one of the transparent electrodes, for example using a screen-printing 429 process. With a deformable upper electrode an applied pressure will act to modify 430 the resistance of this layer. For a matrix array of electrodes, the resistance at each 431 intersection is modified by the pressure-sensitive layer. The intersection with the 432 lowest resistance corresponds to the touch location, and the resistance value indicates 433 the level of applied pressure. For such a layer, several technical requirements must 434 be met. For use in a touchscreen overlaying a display, there must be appropriate 435 light transmission through the layer. The response must be uniform across the layer 436 and be repeatable for a large number of presses. The resistance of the layer must 437 show adequate variation over a range of forces from a light touch (0.1 N to a hard 438 press (10 N), in order to create a number of pressure levels that can be differentiated 439 by the read-out electronics. The layer should also be responsive at very light touches 440 in order to minimize the activation force. Here we review several pressure sensitive 441 layers that can be incorporated into a resistive touchscreen. They all comprise a 442 transparent conductive polymer composite as described in section 2.1.2 deposited 443 between two (transparent) electrodes, but the structure of the composite material is 444 different in each case. 445

Motorola Solutions, Inc. ('Motorola') have developed a transparent pressure sen-446 sitive conducting polymer composite for use in touchscreen applications which is 447 currently patent pending [51]. Conductive nanoparticles less than 100 nm in size. 448 e.g. In-doped  $SnO_2$  (ITO),  $SnO_2$  or ZnO, are dispersed in a translucent insulating 449 polymer such as a phenoxy resin, polyether, acrylic or silicone. The composite can be 450 deposited onto a transparent electrode by spin coating, dip coating or screen print-451 ing and is then cured to produce a layer 1-10  $\mu$ m thick. A prototype multi-touch 452 enabled touchscreen using this pressure sensitive layer has been demonstrated [52]. 453 The particle loading is 20-30 % by volume, and the layer is printed at a thickness 454 of 1  $\mu$ m and sandwiched between perpendicular arrays of transparent conductive 455 electrodes. Optical transmission through the pressure sensing layer is at least 94 456 % of transmission through glass. A contact pressure cannot be established as no 457

<sup>458</sup> information is given on the area of the force-testing probe.



Figure 7: A comparison of the force-resistance response for various touchscreen technologies, reproduced from data provided by Motorola Solutions, Inc. [52], Stantum [56], 3M Innovative Property Company [57] and Peratech Holdco Ltd [62]. The resistance through the touchscreen is measured as a function of applied mass. Lines are drawn for each data set as a guide to the eye.

Instead, a typical force-resistance response is shown in Fig.7, reproduced from 459 data provided in [52]. It can be seen that the resistance decreases exponentially with 460 applied force, dropping from 20 M $\Omega$  at zero load to less than 5 k $\Omega$  for a 1 kg load. 461 However, a significant activation force of 0.04 N (40 g) is required before resistance 462 begins to decrease and so very light touches cannot be detected. Motorola have 463 a number of other patent applications, including the incorporation of the pressure 464 sensitive layer into a device and using the layer to validate touch inputs and eliminate 465 false touch readings [53, 35]. 466

It is possible to further control the conduction pathways by the alignment of 467 magnetic filler particles using an external magnetic field. This effect has been stud-468 ied previously for polymer composites containing nickel particles and carbon nan-469 otubes [54, 55]. By applying an external magnetic field, the particles are aligned 470 into columns which can span one dimension of the composite. In a pressure sensi-471 tive layer, the particles may be arranged into columns spanning the top and bottom 472 electrodes, as shown in Fig.8. A lower particle loading is required to produce the nec-473 essary conduction pathways between the electrodes. Stantum have developed such 474



Figure 8: Conducting magnetic particles are dispersed in an insulating polymer and aligned into columns by applying an external magnetic field. The columns act as conductive pathways between top and bottom electrodes. By compressing the layer, the distance between neighbouring particles decreases, and charge transfer through direct percolation or quantum tunnelling increases, reducing the resistance through the sensor. This principle is used in a force sensing layer developed by Stantum [56].

a layer using this principle, which is currently patent pending [56]. Nickel particles 475 are dispersed in an insulating polymer, for example silicone or polyurethane, at a 476 loading of 0.3-10 % by volume. The nickel particles have a diameter of 2-5  $\mu$ m and 477 have a spiky surface topography, where the surface protrusions can be greater than 478 1  $\mu$ m in length. The composite is deposited as a film 50-100  $\mu$ m thick, and an ex-479 ternal magnetic field of strength 3-10 mT is used to align the magnetic particles into 480 columns spanning the thickness of the printed film. By adjusting the magnetic field 481 strength the cross-sectional diameter of the columns can be altered, but is usually in 482 the range of 20-25  $\mu$ m. By applying a pulsed or sinusoidal magnetic field the cross 483 section can be reduced to 10  $\mu$ m. The strength of the magnetic field also controls 484 the distribution of columns across the film. 485

When the layer is deformed the separation between the particles in each column decreases and more conduction pathways are formed, as shown in Fig.8. The resistance of each pathway may also decrease. It is known that a close proximity between nickel particles as described above can result in field-assisted quantum tunnelling [23, 24]. A force-resistance response for loads up to 500 g is shown in Fig.7, reproduced from data given in [56]. Again, no details on the contact area of the probe are given so contact pressures cannot be calculated. At zero applied force, the resistance is of the order 100 k $\Omega$ . A load of 100 g decreases the resistance to 10 k $\Omega$ , beyond which the resistance decreases marginally for loads up to 500 g. This insensitivity to larger applied forces may limit its applicability. Because fewer particles are required to produce the well-defined conductive pathways, greater optical clarity of the layer can be achieved. However, in practice the large film thickness of 50-100  $\mu$ m will have a detrimental effect on the optical transmission. Details on this have not yet been reported.



Figure 9: Conducting particles are dispersed in an insulating polymer film such that the particle size is of a similar dimension to the thickness of the printed film. With increasing deformation of the upper electrode an increasing number of particles are contacted. This principle is used in transparent force sensor developed by 3M Innovative Property Company [57, 58] and Peratech Holdco Ltd [62], although in the latter the particles themselves also show a decrease in resistance with increasing applied pressure.

In contrast to the methods described above, it is also possible to create a pressure 500 sensing layer by dispersing a very low number of particles in the insulating polymer, 501 provided that the particles are of a size comparable to the thickness of the printed 502 layer. Rather than the conduction occurring through a convoluted pathway of small 503 particles, of which there must be a high enough concentration so as to reach the per-504 colation threshold, instead a low concentration of larger particles provides a series 505 of conduction paths where the particles directly connect the top and bottom elec-506 trodes, as shown in Fig.9. This approach has been demonstrated by 3M Innovative 507 Property Company (3M IPC), who have patented such a layer for use in force sensi-508

tive membranes and touchscreens [57, 58]. The layer, which can be deposited using 509 blade coating (and likely screen-printing for large scale manufacture) is typically 1-510  $10 \ \mu m$  thick and comprises conductive particles, for example ITO or silver-coated 511 glass beads, dispersed in an elastomeric polymer. The particle size is of a similar 512 dimension to the printed layer, such that the top surface of the particle may protrude 513 above the film surface. Spacer dots may be dispersed onto the film surface to prevent 514 initial contact between the film and upper electrode. Upon application of force to the 515 touchscreen, the top electrode deforms and is brought into contact with one or more 516 conducting particles, allowing current to flow. With increasing deformation, the top 517 electrode contacts an increasing number of particles, thus decreasing the resistance 518 between the electrodes. This is purely a surface effect as the resistance depends 519 on the contact area of the touch and the layer is not intrinsically piezoresistive. It 520 has been reported that the resistance R decreases with increasing applied force F521 according to 522

$$R = \frac{A}{F^n},\tag{3}$$

where A and n are constants. The value of n indicates the sensitivity of the sensor 523 where a larger value produces a greater decrease in resistance for a given increase in 524 applied force. For a silicone rubber film of thickness 25  $\mu$ m containing ITO-coated 525 glass fibres the n value was reported to be 1.02 and the force-resistance response for 526 this particular sensor is shown in Fig.7 which is reproduced from data provided in 527 [57]. No details of the contact area of the force-testing probe are provided. It can 528 be seen that the resistance decreases from 10 k $\Omega$  under a load of 40 g to around 529 20  $\Omega$  at 800 g. There is no data provided for loads higher and lower than this so 530 first touch sensitivity cannot be assessed. The optical transmission through a 60 531  $\mu$ m film containing silver coated glass beads with diameter 43  $\mu$ m dispersed at a 532 concentration of 140 particles per  $mm^2$  was reported to be 91 % over the visible 533 wavelengths 400-700 nm. 534

One potential issue in this type of pressure sensitive layer is the susceptibility of 535 the upper electrode to damage from prolonged and repeated contact with protruding 536 particles. Many transparent conducting electrodes suffer from poor durability under 537 flexing. This is widely reported for ITO on flexible substrates and is one of the driving 538 forces for developing a replacement for ITO [50]. Abrasion with hard particulates 539 will further decrease the durability and lifetime of the sensor. One solution would be 540 to use other transparent conducting electrodes such as graphene, metal nanowires, 541 or carbon nanotube dispersions, all of which show enhanced durability over ITO [59, 542 60, 61]. Alternatively, as described in the patent [57], it is possible to fill the air gap 543

<sup>544</sup> between particles and top electrode with an insulating filler material which acts as <sup>545</sup> a buffer material between electrode and particle.

A similar pressure sensitive composite layer has been developed by Peratech Ltd, 546 since renamed Peratech Holdco Ltd ('Peratech) [62]. However in this case the par-547 ticulates are agglomerates of many smaller conductive particles, e.g. spherical or 548 acicular antimony-doped tin dioxide (ATO) particles with diameter 200 nm (and a 549 length of 0.2-2  $\mu$ m for the acicular particles). These are dispersed in an insulating 550 polymer such as acrylic and/or polyvinyl resin, at a loading of 0.1-0.5 % by mass. 551 The agglomerates have typical dimensions of 5-15  $\mu$ m and are either formed as the 552 constituent particles are mixed into the insulating polymer, or they can be pre-formed 553 before adding to the polymer. A further patent details one possible composition of 554 such pre-formed granules [63]. 555

With increasing applied pressure, more agglomerates are brought into contact 556 with the top electrode thus reducing the resistance through the layer, similar to 557 the 3M IPC composite layer. However, the patent also infers that the agglomerates 558 themselves are inherently pressure sensitive, such that a compressed agglomerate will 559 exhibit a lower electrical resistance than when at rest. By compressing the agglom-560 erates, the inter-particle voids are reduced and more of the constituent particles are 561 brought into contact. Quantum tunnelling of electrons may occur from one particle 562 to the next if the potential barrier caused by the insulating polymer binder is suffi-563 ciently narrow. The sensitivity is thus governed by surface and bulk effects, due to 564 an increasing number of agglomerates contacting the upper electrode with increas-565 ing applied pressure, and the resistance of individual agglomerates decreasing due to 566 compression. 567

The force resistance response of a layer comprising 0.2 % ATO agglomerates dispersed in an insulating varnish was determined using a probe tip of 8 mm diameter to apply a force of 0.15–5 N. The response of the touchscreen is shown in Fig.7, reproduced from data provided in [62]. The resistance changes from 15 k $\Omega$  to 2 k $\Omega$ when the load is increased up to 500 g. The optical transmission through this layer is 98 % when compared to transmission through the ITO/glass electrode.

This layer, marketed as QTC<sup>™</sup> Clear, is used in FineTouch Z - a pressure sensitive transparent touch panel produced by a partnership between Stantum and Nissha Printing Co. Ltd [64]. FineTouch Z uses Stantum's iVSM technology and is capable of detecting 256 levels of pressure [65], with possible applications including palm rejection (when operating the touchscreen with a passive stylus), dynamic capture of handwriting, and fine control when using the device for drawing applications.

Fig.7 compares the variation in resistance response with applied force for each pressure-sensitive resistive touchscreen discussed. Direct comparison between each

touchscreen is difficult as exact details regarding the build, for example the depth of 582 the air-gap and the mechanical flexibility of the upper substrate, are not divulged. 583 Also, the contact area of the probe used for the force-resistance measurements in each 584 case is not always given, so the applied pressure cannot be calculated. However, 585 some conclusions may still be drawn. The greatest range in resistance is seen for 586 the touchscreen developed by Motorola, where the resistance drops over four orders 587 of magnitude for loads between 40 g to 1 kg. However, a minimum load of 40 g is 588 required to produce an initial response. Because of the nature of the pressure sensing 589 layer, a large force may initially be required to provide the necessary deformation 590 to the polymer in order to increase the number of conduction pathways. For the 591 Stantum touchscreen, a decrease in resistance is observed above 3 g, but above 100 g 592 there is no further significant decrease in resistance. Because there is initially a close 593 proximity between neighbouring nickel particles in the column, a small activation 594 force may be required to create the initial contact between the upper electrode and 595 nearest particle, after which current can flow down the column without requiring 596 further deformation of the layer. The touchscreens demonstrated by Peratech and 597 3M show a decrease in resistance over the full range of applied loads without the 598 ultra-sensitive response of the Motorola touchscreen or the lack of sensitivity at 599 high loads shown by Stantum. The resistance values for the 3M touchscreen are 600 consistently lower than those demonstrated by Peratech, and the resistance drops 601 below 100  $\Omega$  for loads greater than 200 g. High current flow leading to high power 602 usage may be detrimental in some applications. In order to use the resistive layer 603 as a voltage divider in a touchscreen assembly as described earlier, the resistance 604 should not fall below that of the connectors and read-out circuitry. In this case, the 605 Peratech pressure sensing layer is advantageous. For both the 3M IPC and Peratech 606 results there is no resistance value reported for zero applied load. However, this 607 can be adjusted by control over the air-gap and mechanical flexibility of the upper 608 electrode. 609

## 610 4.3. Other Touchscreen Technologies

## 611 4.3.1. Surface and Bending Wave

When an object impacts onto a rigid material, such as a finger contacting a touchscreen, both surface and bending waves propagate through the material. Whilst surface acoustic waves propagate on the substrate surface only, bending waves travel though the full thickness of the substrate, radiating outwards from the location of the touch. During a touch event, a number of surface and bending waves of different frequencies are produced which propagate through the touch interface at different speeds. Bending waves may also undergo reflections at the interface between internal <sup>619</sup> surfaces of the substrate. Sensors at the edge of the substrate receive this complex <sup>620</sup> signal, which is then used to determine the location of the touch.

Both Acoustic Pulse Recognition (APR) patented by Elo Touchsystems [66] and 621 Dispersive Signal Technology patented by 3M [67] use bending waves in order to 622 extract the touch signal. Both of these technologies use four piezoelectric transduc-623 ers located asymmetrically on the substrate perimeter which convert the measured 624 pressure from the acoustic wave to a voltage. However, the signal processing algo-625 rithms can currently only differentiate between touch input from various points on 626 the touchscreen surface and cannot differentiate between different touch forces and 627 so currently this technology is not pressure-sensitive. 628

Conversely, in Surface Acoustic Wave (SAW) touchscreens, the piezoelectric trans-629 ducers send bursts of ultrasonic Raleigh waves across the touch surface in response 630 to a supplied voltage. Reflectors at the edges of the touchscreen reflect the acous-631 tic wave back across the screen and into the relieving piezoelectric sensors, which 632 convert the pressure input back to a voltage. The transit time of the wave depends 633 on its path length so that each physical location can be mapped into the time do-634 main. When a human finger, or indeed any other sound-absorbing object touches the 635 screen some of the Raleigh waves are absorbed. By measuring where the reduction 636 in the wave amplitude occurs the touch location can be determined. The amount of 637 reduction in the signal amplitude can in principle be used to determine the touch 638 pressure. The IntelliTouch touchscreen produced by Elo Touch Solutions uses this 639 principle and it is stated that pressure-sensing is possible. However no information 640 is given about the levels of pressure that can be detected, beyond that a minimum 641 of 85 g activation force is required [68]. To the authors knowledge, there are no de-642 vices currently available on the market that utilise the pressure-sensing capabilities 643 of SAW touchscreens. 644

#### 645 4.3.2. Optical Sensing Touchscreens

An infrared (IR) touchscreen typically consists of two IR LEDs along two adjacent 646 sides of the touch surface and two receiving IR photodetectors on the other sides 647 (i.e. a transmitter and receiver for both X and Y coordinates). The transmitters are 648 pulsed sequentially, so that when the surface is touched, the IR beam is broken and 649 the touch location can be calculated. Pressure information cannot be calculated as 650 the touch force does not impact in any way on the IR photodetector. In camera-651 based optical touchscreens, IR LEDs provide a peripheral backlight across the touch 652 surface with cameras placed in two or more corners of the screen which can detect the 653 presence or absence of light. When a finger touches the screen the peripheral light 654 is blocked and the cameras observe a shadow. Again, pressure information cannot 655



Figure 10: (a) Four discrete force sensors placed underneath a touch interface or display may be used to determine both the location and force of a single touch. (b) Data for the resistance response of a touch display demonstrated by F-Origin, where resistance decreases with increasing applied force.

<sup>656</sup> be recorded by this technology. To the authors knowledge, there are no pressure– <sup>657</sup> sensing touchscreens available which utilise the optical pressure–sensing mechanism <sup>658</sup> described in Section 2.

# 659 4.4. Pressure Sensors External to the Touchscreen

The previous sections described the incorporation of pressure sensors directly 660 into the touchscreen assembly where the pressure sensing components are intrinsi-661 cally part of the touchscreen assembly. There is an alternative method of adding 662 pressure sensitivity, where pressure is assessed outside of the touch module. The 663 pressure sensors may be found underneath the display, or even overlaid on top of 664 the touchscreen in a transparent array. Pressure sensitive styli may also be used 665 which send pressure information directly to the device controller or to specialised 666 applications which can utilise these pressure levels. 667

# 668 4.4.1. Force Sensors underneath the Touch Interface

It is possible to incorporate discrete force or pressure sensors underneath the display unit. In fact, some touchscreens utilise this concept to measure both the location and the force of the touch, rather than detecting touch indirectly through a change in resistance or capacitance between two electrodes. These touchscreens <sup>673</sup> comprise four discrete force sensors underneath the four corners of the interface as <sup>674</sup> shown in Fig.10(a). The sensors used may be any of those described in section 2 such <sup>675</sup> as strain gauges, piezoelectric transducers, capacitance sensors, inductance sensors <sup>676</sup> or even force sensitive resistors, where each has its own benefits and drawbacks [69]. <sup>677</sup> These are summarised in Table 1. In the touchscreen industry, this type of touch <sup>678</sup> interface is usually referred to as 'force-based' to distinguish it from other technologies <sup>679</sup> such as resistive or capacitive.

Analysis of the force or pressure recorded at each corner allows determination of the touch location. Whilst only three forces are necessary to triangulate the touch location, when pressed the touch surface will always undergo a small degree of deflection (as no surface may be classed as truly rigid) and the addition of a fourth sensor allows the effect of the deflection on the sensors to be accounted for. In addition, four sensors can easily be integrated into the common rectangular design of most touch panels.

Simplistically, the touch coordinates X and Y can be calculated by moment equations:

$$X = \frac{F3 + F4}{F1 + F2 + F3 + F4}, \quad Y = \frac{F1 + F2}{F1 + F2 + F3 + F4}$$
(4)

The touch force Z is simply equal and opposite in magnitude to the sum of the forces measured at each sensor.

$$Z = -(F1 + F2 + F3 + F4) \tag{5}$$

This concept first showed commercial success in 1991 when IBM developed their 691 TouchSelect overlays for CRT (cathode ray tube) monitors, where the CRT screen 692 was mounted on strain gauge force sensors [70, 71]. However, the product only 693 lasted 3 years on the market and overall was unsuccessful. For force to be mea-694 sured accurately, the movement of the screen or cover glass must be constrained to 695 the downward (z) direction only, eliminating any lateral or off-axis forces. Because 696 a touch event is not static and constant, the algorithm must account for any dy-697 namic force profile measured at the force sensors. If these effects are not taken into 698 consideration, the accuracy of the device in determining touch location is severely 699 limited. 700

<sup>701</sup> Several attempts have been made to overcome these issues. QSI Corporation <sup>702</sup> developed their force sensing touch technology InfiniTouch<sup>TM</sup> using a beam mount-<sup>703</sup> ing method, whereby the beams absorb most of the lateral forces. An accuracy of <sup>704</sup> 1% across the X and Y dimensions is reported [72]. Furthermore, if the touch sur-<sup>705</sup> face is constructed from a rigid material, and under normal operation is subject to

stresses well below the limits of the material, then the effect of pre-stressing and over-706 constraint of the beams is negligible. The company F-Origin, Inc. have patented a 707 different design which removes the issue of lateral forces. Their force sensing touch 708 panel zTouch<sup> $\mathbb{M}$ </sup> uses a suspension spring arm method, where the screen is supported 709 by a looped filament or string, thus removing frictional forces [73, 74]. Furthermore, 710 computing power has increased significantly since the 1990s, and digital signal pro-711 cessing integrated chips can be readily and cheaply obtained which are more than 712 capable of processing the dynamic force waveforms from each of the four sensors. 713 An example force–resistance response demonstrated by F-Origin zTouch<sup>™</sup> is shown 714 in Fig.10(b). 715

The major drawback with this technology is that usually these devices are only 716 capable of detecting a single touch event. If the screen is touched in more than one 717 location, the centroid of the applied forces will be calculated. In order for the device 718 to become multi-touch, multiple force-sensing areas are required. For a grid of  $n \times n$ 719 force sensing areas, assuming there is a sensor at each corner of the discrete force 720 sensing areas, a total of  $(n+1)^2$  sensors are required. For a high resolution force 721 response where a large n is required, the number of sensors necessary becomes very 722 large and the complexity of the system escalates. The exception to this is Force-723 Touch<sup>™</sup> developed by NextInput, Inc. who use an array of micro-electromechanical 724 (MEM) force sensors underneath the touch interface to detect touch location and 725 touch force to sub-millimeter and sub-millinewton resolution [75]. Furthermore, the 726 addition of force sensors may add to the overall device thickness and weight. 727

The majority of applications for this technology make use of its other benefits 728 rather than the addition of force sensitivity. These include the detection of touch 729 from any object, conductive or insulating and the rugged and durable nature of the 730 technology which is resistant to surface contamination. The touchscreen is usually 731 cheap to manufacture as the cost is not dependent on the area of the touchscreen 732 - large displays are feasible. Finally, the touch interface itself may be patterned, 733 for example with drilled holes, textured areas or embossed Braille characters. These 734 benefits make force based touchscreens ideal for outdoor applications, or other ap-735 plications that need to withstand rough handling, input from gloved hands, contam-736 inants such as dust and liquids, and extreme temperatures. Example applications 737 include ATMs, information kiosks and industrial control panels. Of course, in any of 738 these applications the force sensitivity may be used as an additional controllable in-739 put. However, due to the issues highlighted above, it is unlikely that this technology 740 in its current state would ever replace the industry standard projected-capacitive 741 touchscreens which are at present found in most smartphones and tablets. 742

<sup>743</sup> In order to achieve pressure sensitivity along with the multi-touch capability

of a capacitive touchscreen, a hybrid approach may be used. The touch location is
calculated using a P-Cap touchscreen or similar (which has multi-touch capabilities),
and the force of the touch is determined using the discrete force sensors. These
so-called hybrid touchscreens provide a beneficial solution for applications such as
smartphones and tablets where multi-touch is now a standard and necessary feature.

The hybrid approach can already be found in projected-capacitive laptop track-749 pads, as described in Section 4.5.3. Furthermore, Apple, Inc. also hold a patent 750 detailing the inclusion of force sensors into trackpads and touchscreens [76, 77]. A 751 recent press release states that the newly developed Apple Watch will have a pres-752 sure sensitive transparent touch interface which is capable of differentiating between 753 a light tap and a hard press, where the hard press is used to shortcut to a specific 754 demand [78]. The force sensors used can be strain gauges, capacitive membranes, 755 silicone diaphragm or any other suitable force sensor. In [77], the FSR is described 756 as one possible force sensor. 757

#### 758 4.4.2. Pressure Sensitive Stylus

A stylus may be described as passive or active. A passive stylus comprises any 759 conductive object, for example a metal rod, conductive plastic or conductive rubber-760 tipped pen, which can be used to replace finger-touch on a touchscreen. Passive 761 styli are low cost, easily replaced and can be made to any size required. However, 762 they provide no more resolution or functionality than the human finger. Active 763 styli are typically enhanced with additional functionalities such as pressure and tilt 764 measurement and require a power source in order to operate, which can either be 765 drawn from the device or provided by an internal battery supply. 766

Electromagnetic resonance (EMR) styli draw their power from the device they 767 are coupled with. The device has an additional sensing or 'digitiser' layer underneath 768 the display in addition to the capacitive touchscreen overlaid on top of the display. 769 The magnetic field generated by this layer induces a current in the stylus when it 770 is within range of the device. The stylus uses this current to relay information on 771 the use of the stylus (e.g. location, tilt, pressure) back to the touchscreen controller. 772 An example of this type of stylus is the Samsung S-Pen (manufactured by Wacom 773 Co. Ltd.) for the Galaxy Note 4 which can differentiate 2048 levels of pressure. 774 The device allows for both capacitive input through finger-touch and stylus input 775 through the digitiser layer. Whilst the stylus allows high-resolution pressure input, 776 the addition of the digitiser layer adds to the thickness and weight of the device. An 777 increased distance between the surface and the digitiser layer can lead to parallax 778 issues, where the line is not drawn directly under the pen, as seen by the user. 779

780 Without a digitiser layer, the stylus requires an internal battery. N-Trig devel-

oped the DuoSense active stylus, which uses the same controllers as the capacitive
touchscreen, i.e. it does not require an additional digitiser layer and instead uses
an internal battery. The DuoSense can detect 256 levels of pressure. The Wacom
Bamboo fineline is advertised for use with the Apple iPad and gives 1048 pressure
levels. However, both of these styli are only supported by specific applications.

The pressure sensitivity is realised by the incorporation of a pressure sensor within 786 the stylus, usually connected to the stylus nib such that retraction of the nib triggers 787 the pressure sensor. Wacom. Co. Ltd. hold a patent detailing the use of an inductive 788 style pressure sensor within a stylus, whereby the sensor is not constrained to detect 789 axial forces only. This means that the stylus shows high pressure sensitivity at low 790 pressures, even when the stylus is held in a non-vertical writing position. Wacom 791 also hold a patent which utilises a conductive polymer composite as a pressure sensor, 792 where the composite consists of spherical carbon particles of diameter  $1-20 \ \mu m$  and 793 hollow elastic microspheres of diameter  $10-150 \ \mu m$  dispersed in an insulating silicone-794 based polymer. They state that this particular conducting polymer composite shows 795 high repeatability with a low amount of hysteresis [79]. 796

The pressure sensor used may also be optical, whereby movement of the stylus nib 797 causes partial coverage of an LED light source or similar. The attenuation of the light 798 signal is picked up by a photodetector and can be measured as a function of applied 799 force on the nib [80, 81]. Otherwise, the pressure sensor may be capacitance based, 800 whereby depression of the stylus nib causes one conductive plate to move relative 801 to another such that the areas in direct opposition to one another are altered, thus 802 changing the capacitance measured between the plates [82, 83]. BlackBerry Ltd. 803 describe a pressure–sensitive stylus where pressure is detected through a change in 804 air pressure inside an internal cavity within the stylus, when compared to external 805 air pressure [84]. 806

The advantage of these styli include their high pressure sensitivity, as these devices can typically differentiate between 256 and 2048 levels of pressure. Because only a single sensor is required, and the housing is large (the size of a typical pen) there is less constraint on the physical dimensions of the sensor.

However, the major disadvantage is that the stylus use and performance depends 811 not only on the pressure-sensing capabilities of the pen, but also the display, chip, 812 controller and driver support. For example, currently Apple products have no in-813 built pressure sensing capabilities in the touch screen. A pressure–sensing stylus 814 would only work on specifically designed applications which can utilise this pressure 815 sensitivity – and they may not utilise all pressure levels inherent in the pen. New 816 devices such as the Samsung Galaxy Note series have an in-built digitiser layer which 817 supports stylus input, and a range of applications in which the pressure-sensing 818



Figure 11: Force sensitive resistor. The active layer, consisting of small particles dispersed in a polymer binder, is screen-printed directly onto a flexible substrate and separated from interdigitated electrodes by a spacer. Upon application of pressure, the active layer is pushed into contact with the electrodes.

capabilities can be utilised. However, the stylus provided will works solely for this device, and is expensive to replace if lost.

# 821 4.5. Keyboards and Trackpads

#### <sup>822</sup> 4.5.1. Force Sensitive Resistors

The force sensitive resistor (FSR) was first patented in 1977 by Franklin Eventoff [85]. 823 An active resistive layer is screen printed onto a flexible substrate, and separated from 824 a set of inter-digitated electrodes by a spacer layer such as a ring of insulating ma-825 terial which maintains air flow into and out of the cavity, as shown in Fig.11. In 826 another format, the active layer is printed directly onto one electrode and separated 827 from the second by the spacer. When the top layer is pressed the electrode(s) deforms 828 into the spacer layer and comes into contact with the active layer. With increasing 829 force a larger area of the active layer is in contact with the electrodes, decreasing the 830 electrical resistance through the sensor. 831

The active layer in its most basic form is a screen-printable conductive polymer composite as described in Section 2.1.2, where the conductive particles are embedded into a printable base polymer. When printed, the active layer has micro or nanoscale surface protrusions, depending upon the size of the constituent particles. The resistance is highly dependent on the contact area, which itself is dependent on the



Figure 12: Force-resistance response of FSR sensors manufactured by Interlink Electronics, Sensitronics LLC and Peratech Holdco Ltd. In each case forces up to 10 N were applied using a load cell with a rubber probe with an 8 mm diameter. For each sensor, the resistance decreases over three orders of magnitude with increasing applied force.

<sup>837</sup> force applied to the upper electrode.

For example, Interlink Electronics have patented an ink containing SnO particles of size 0.5-10  $\mu$ m which create micro-protrusions at the surface of the ink, thereby increasing the number of electrical contact points between electrode and ink with increasing force [86]. The sensitivity of the response can be further controlled by the number and spacing (pitch) of the inter-digitated fingers, where a finer pitch will increase the dynamic range of the FSR.

In other commercial FSRs, the active layer itself is piezoresistive. Tekscan, Inc. 844 describe an active layer which consists of a network of carbon black particles 1-1000 845 nm in size, dispersed in a polymer binder [87]. As shown in Fig.1, with increasing 846 force a greater number of the particles within the active layer are brought into direct 847 contact or close enough for quantum tunnelling of electrons to occur, thus decreas-848 ing the electrical resistance of the layer. Similarly, Peratech Holdco Ltd license a 849 quantum-tunneling ink which contains both spherical insulating particles and aci-850 cular semiconducting particles [88]. Evidence suggests that charge transfer occurs 851 via direct conduction and more significantly quantum tunnelling between the acic-852 ular particles [89]. The change in resistance can be attributed to both the change 853

in contact area and the change in conductivity of the active layer. Fig.12 com-854 pares the force-resistance responses of three commercial FSR sensors - a 0.5 inch 855  $FSR^{\mathbb{T}}$  402 manufactured by Interlink Electronics (£5.42 per unit [90]), a 0.5 inch 856 FSR101 ShuntMode<sup>™</sup> manufactured by Sensitronics LLC (unit price \$6 USD [91]) 857 and a  $QTC^{\mathbb{M}}$  sensor manufactured by Peratech Holdco Ltd (no pricing available). 858 In each case, the active layer is printed onto inter-digitated electrodes as shown in 859 Fig.11 and the sensor was loaded with forces up to 10 N using a load cell with a 860 rubber probe of diameter 8 mm. It can be seen that for each sensor the resistance 861 varies over three orders of magnitude when forces up to 10 N are applied, where the 862 resistance decrease has a power law dependence on the applied force, with the expo-863 nent varying in the range -0.6 to -0.9. For the Peratech and Sensitronics sensors 864 the response shows signs of saturation at higher forces. However the Interlink sensor 865 shows a decrease in resistance even up to 10 N applied force. The activation force 866 (the minimum force required to produce a decrease in resistance) is of the order of 867 0.15 N. This range of response makes FSR technology suitable for detecting many 868 levels of applied force, from a light touch (0.1 N) to a hard press (10 N). 869

A further benefit of FSR technology is that it can be manufactured using low-870 cost large–area printing methods and as a component is easy to integrate into a 871 device. The sensors are lightweight and thin, typically no more than 1 mm total 872 thickness [92]. The sensor performance in terms of its sensitivity, activation and 873 saturation forces (the force at which the resistance has levelled to a minimum value) 874 can be controlled by the mechanical design of the sensor. The saturation force is a 875 function of the area of applied force and the spacing of the inter-digitated fingers. 876 FSR sensors tend to be insensitive to high frequency vibrations and acoustic noise 877 pick-up. This can be useful in some applications in avoiding cross-talk between sen-878 sors. However, the reproducibility of the response can often be poor. For example, 879 the FSR(R) 400 Series manufactured by Interlink Electronics quotes a batch to batch 880 variation of resistance response of 6 %. Variation across a single sensor is quoted 881 as 2 %. This stems from the inherent batch to batch variations common in printed 882 technologies and also hysteresis effects caused by the mechanical relaxation of the 883 host polymer. Whilst this variation means that the sensor is not suited to precise 884 measurement of force, it is appropriate for use in tactile sensors where only approxi-885 mate levels of applied force are required. The recovery speed of the sensor is limited 886 by its mechanical rise time (i.e. the time taken for the deformed active layer to 887 return to its original position) which is typically quite slow at 1-2 ms. Finally, the 888 FSR can show a drift in resistance for a constant applied load. Whilst this drift is 889 reversible, for applications where measurement of a static force is required, the drift 890 must be taken into consideration. 891



Figure 13: (a) Dismantled view of Microsoft Surface Touch Cover, a pressure sensitive keyboard containing FSR sensor technology. (b) An insulating spacer ring is printed directly onto the active layer of each FSR sensor. (c) Inter-digitated electrodes are printed directly onto the bottom substrate.

Primary applications for FSR sensors include biomedical, e.g. pressure mapping 892 whilst walking [93], robotics [94] and musical synthesizers [95]. Various articles com-893 pare FSR technologies and describe their applications in these fields [92, 96, 97, 98]. 894 FSRs can currently be found in some computer keyboards and laptop trackpads [? 895 ]. FSR sensors are used in the VersaPad(R) trackpad produced by Interlink Elec-896 tronics. This consists of two FSR sensors sandwiched together and separated by 897 spacer dots, and is offered as a rugged alternative to traditional projected-capacitive 898 trackpads that can be used in high humidity environments or with gloved hands. 899 The UnMousePad is a multi-touch location and pressure sensing trackpad using 900 FSR technology, developed by TouchCo, Inc. in 2009 [99]. The Microsoft Touch 901 Cover is a pressure sensitive keyboard for integration with Microsoft Surface tablets. 902 Underneath each letter key is an FSR sensor measuring 15 x 15 mm and a set of 903 inter-digitated electrodes, as shown in Fig.13. Microsoft Corp. hold a relevant patent 904 detailing this system [100]. The pressure sensitivity is used to dismiss light touches 905 as accidental and for rejecting unintended touch from the palm of the hand (palm 906 rejection). Other possible uses detailed in the patent include using force to change 907 the size, colour or case of text input and also for gaming applications. Because 908 there are no moving parts, the keyboard is thinner and lighter (2.75 mm and 185 g)909 with a greater product lifetime compared to mechanical keyboards. The 'quantum 910 tunnelling' ink licensed by Peratech Holdco Ltd is used in the 909 TouchPro drill 911 produced by GlobalPowerBrands Int. Pty Ltd. Here the pressure sensitivity is used 912 to control the speed of the drill rotation. 913



Figure 14: (a) The structure of  $PyzoFlex(\mathbf{\hat{R}})$  foil, consisting of the piezoresistive layer sandwiched between two electrode arrays, either carbon-based or PEDOT. Compression of the film induces a measurable voltage. (b) The  $PyzoFlex(\mathbf{\hat{R}})$  foil produces a highly linear pressure–voltage response (data reproduced from [101]).

914 4.5.2. Piezoelectric Foil

PyzoFlex(R) foil, developed by Media Interaction Lab, is a pressure sensitive print-915 able film. A piezoelectric ink containing randomly orientated nano-crystals of the 916 copolymer P(VDF-TrFE) is printed at a thickness of 5  $\mu$ m onto an electrode, which 917 can be a screen-printable carbon-based ink or a transparent conducting polymer such 918 as poly(3,4-ethylenedioxythiophene) (PEDOT), as shown in Fig.14(a). After print-919 ing the dipoles are aligned by poling. The top and bottom electrodes are connected 920 perpendicularly so that a voltage signal can be read out from each electrode-PVDF-921 electrode intersection. Under applied pressure, or a change in temperature caused 922 by a hovering finger, a voltage change can be detected due to redistribution of the 923 dipoles, as demonstrated previously in Fig.2. Prototypes of the  $PyzoFlex(\mathbf{\hat{R}})$  foil have 924 been demonstrated, where pressures as low as  $0.12 \text{ N/mm}^2$  produced a voltage of 925 the order of 0.1 V [101, 102]. The piezoelectric coefficient is between 20–30 pC/N. 926 The pressure-voltage response of the  $PyzoFlex(\mathbf{\hat{R}})$  material, is shown in Fig.14(b), 927 reproduced from data provided in [101], where forces were applied using a test probe 928 4.5 mm in diameter. It can be seen that for applied pressures in the range 0.12-0.29929  $N/mm^2$  (corresponding to applied forces from 1.9–4.7 N) the voltage output is highly 930 linear. No data is provided for pressures above  $0.29 \text{ N/mm}^2$  so the saturation force 931

932 cannot be determined.

However, there are still many issues with this sensor. Perhaps the main disadvantage is that the sensor cannot detect a dynamic force unless additional complex signal processing algorithms are used. This is because during application of a static force the induced voltage discharges through the internal resistance of the PVDF layer. The sensor can only truly detect a dynamic applied force.

Because the touch signal is small, both amplification of the signal and reduction of 938 background noise via a noise filter is required. Signal noise is introduced from infra-939 red light found in ambient lighting, and from cross-sensitivity between the piezo-940 and pyroelectric responses. Furthermore, the detection of multiple adjacent touches 941 on the PyzoFlex(R) foil is currently problematic due to cross-talk between adjacent 942 sensors. However, this technology shows potential in that the highly linear response 943 facilitates mapping of the pressure levels, and the technology is suited to flexible 944 applications. It is also possible to create a transparent sensor array by replacing the 945 carbon electrodes with a transparent alternative such as PEDOT or a nanoparticle-946 based ink. Media Interaction Lab state that  $PyzoFlex(\mathbf{\hat{R}})$  foil has applications in 947 flexible displays using OLED display technology, although in principle it may be 948 used in conjunction with any touch interface. 949

### 950 4.5.3. Projected-Capacitive Trackpads

The majority of laptop computers replace the mouse with an integrated trackpad. The trackpad consists of a location-sensing surface and perhaps one or two discrete buttons which provide a click function. For some trackpads, the entire trackpad is hinged such that pressing down in an area opposite to the hinge location (usually the bottom of the trackpad) provides the click mechanism.

The principles of projected–capacitive location sensing have previously been described in Section 4.1.1 where this technology is described for transparent touchscreen applications. The principles are essentially the same, except that of course a trackpad does not require a transparent touch surface, or transparent connecting electrodes.

Pressure–sensitivity may be incorporated into these trackpads by means of placing 960 discrete force sensors external to the touch surface, for example underneath the touch 961 surface. Location sensing is still achieved by projected-capacitive sensors. The 962 details of this method have been described fully in Section 4.4.1. This approach has 963 already achieved commercial success in laptop trackpads. ForcePad<sup>™</sup> V.4 produced 964 by Synaptics, Inc [103] can be used to define force-sensitive multi-touch gestures [104, 965 105]. Four force sensors underneath the corners of the trackpad allow the detection 966 of up to 1000 g from up to five fingers simultaneously with 15 g resolution, and 967 is converted into 64 discrete force levels. The hinge mechanism of the traditional 968

trackpad (which allows for click input) is no longer required as the user can click anywhere on the trackpad by applying a force above a predetermined threshold. In this case, the lack of moving mechanical parts could enhance the product lifetime.

At the time of writing, Apple have released another update which states that their newly developed force-sensing technology, called Force Touch, will be present in the new generation of MacBook trackpads. Here, four force sensors are incorporated underneath the trackpad, such that the trackpad can register many levels of pressure which can be used for force-enhanced gestures such as zooming or scrolling.

Another method of including pressure–sensitivity is the inclusion of optical–based pressure sensors within the trackpad structure. The Synaptics ForcePad<sup>™</sup>V.3 detects applied pressure uses an image–sensing array in the trackpad. This relates the size of the contact area to the pressure–applied by the fingertip. If a hard press is detected (larger contact area between fingertip and touch interface) the click function is activated.

Application	Examples	Location Sensing Mechanism	Pressure Sensing Mechanism	Sensor Details	Pressure Sensing Capabili- ties	Advantages	Disadvantages
Keyboard	Microsoft Surface Touch Cover 2	Resistive – con- ducting polymer composite (FSR)	Resistive – con- ducting polymer composite (FSR)	One sensor measuring 15 mm x 15 mm underneath each key	Need only distinguish light touch and hard press for palm-rejection functional- ity	Keyboard is thinner and lighter than for traditional mechanical keys (2.75 mm and 185 g) Pressure sensitivity removes need for mechanically moving parts	Currently there is no haptic feedback when pressing each key
Laptop Trackpad	Interlink VersaPad™	Resistive – con- ducting polymer composite (FSR)	Resistive – con- ducting polymer composite (FSR)	One large continuous FSR sensor 41 x 57 mm under- neath trackpad surface	Capable of detecting 256 levels of pressure although this feature is not utilised in the VersaPad <sup>™</sup>	Trackpad can detect input from any object Thin and lightweight compared to capacitive-style trackpads (15 g) Can be used in extreme environ- ments such as high humidity	A minimum activation force is required to register a touch event Multi-touch functionality is not supported
	PyzoFlex(k) prototype only	Piezoelectric (PVDF-TrFE copolymer)	Piezoelectric (PVDF-TrFE copolymer)	Printed array of 16 x 8 piezoelectric sensors cover- ing an area of 210 x 130 mm <sup>2</sup> Each sensor has 10 mm ra- dius and thickness of 50 $\mu$ m plus 175 $\mu$ m substrate thickness [101, 102]	Capable of detecting ap- plied pressure from 0.1-0.3 N/mm <sup>2</sup> (2-5 N)	Highly linear pressure sensing re- sponse May have applications for touch- screens if transparent electrodes are used Sensors can be fabricated using a low-cost print process Suitable for flexible applications	Can only detect a dynamic force unless com- plex signal processing algorithms are used Sensitive to electromagnetic noise and cross- talk between sensors Currently only low spatial resolution but this can be improved by increasing the spatial density of sensors
	Synaptics For- cePad <sup>™</sup> v.3	Projected capaci- tive	Algorithm relat- ing contact area with applied force	No physical sensors, algo- rithm only	Detection of force above pre-determined threshold to activate click function	Pressure sensitivity removes need for mechanically moving parts Trackpad is thinner and lighter than competitors (as thin as 1 mm)	Cannot distinguish multiple pressure levels Algorithm requires calibration prior to use Lack of haptic feedback associated with click
·	Synaptics For- cePad <sup>™</sup> v.4	Projected capaci- tive	Individual force sensors under- neath four cor- ners of trackpad surface	Sensor type is undisclosed but is likely to be strain gauge, piezoelectric, ca- pacitive or similar	64 levels of pressure, up to 7 N force, from 5 fingers si- multaneously	Pressure sensitivity removes need for mechanically moving parts Trackpad is thinner and lighter than competitors (3 mm) 64 pressure levels allow pressure sensitive gestures	Lack of haptic feedback associated with click
Force or pressure sensors underneath the touch interface	QSI Corp. Infini- Touch <sup>™</sup> F-Origin Inc. zTouch <sup>™</sup> NextInput, Inc. ForceTouch <sup>™</sup>	Force/pressure sensors external to touch interface	Force/pressure sensors external to touch interface	Piezo-resistive sensors un- derneath four corners of interface		Detection of touch from any object Rugged and durable touch interface is not sensitive to screen contami- nants Cost is independent of area of touch interface Touch interface can be patterned or 3D	Only a single touch can be detected Friction or bending effects must be fully ac- counted for in order to achieve accurate lo- cation sensing
				Array of MEM force sen- sors underneath the dis- play interface allows for multi-touch location and pressure sensing	Pressure sensing with sub- mN resolution		
Capacitive Touch- screen	Research only (al- though this tech- nology is used in Samsung ST550 and TL220 camera touch- screens for location sensing only)	In-Cell pressed capacitive array	Capacitive pres- sure sensor	Sensor array 5 x 5 mm unit size at thickness 750 $\mu$ m (excluding lower ITO elec- trodes) [40]	Detection of up to about 0.1 N applied force	Good transparency (¿ 86%) Suitable for flexible applications	Low signal to noise ratio Unsuitable for high-end applications such as smartphones and tablets due to issues with capacitive coupling with other device com- ponents
				20 x 20 sensor array with 2 x 2 mm sensor size at thickness 253 μm [38, 39]	Detection of up to 5 N ap- plied force		
	Apple Watch Blackberry Sure- Press™	Projected capaci- tive	Individual force sensors un- derneath four corners of touch- screen/display modules	Sensor type is undisclosed but likely to be strain gauge, piezoelectric, ca- pacitive or similar	Apple Watch will be able to differentiate between a light touch and a hard press	Easy addition of pressure sensing to any location sensing device Sensors are entirely separate to touchscreen hence need not be transparent Multi-touch location sensing is sup- ported	Sensors may add to overall thickness of de- vice Lateral forces on the sensors need to be elim- inated to ensure accurate pressure readings Complex algorithm may be required to ex- tract force from dynamic force profiles mea- sured at each sensor
	Active Stylus e.g. Samsung S-Pen for Galaxy Note 4 (2048 pressure levels) N-Trig Active Pen (248 pressure levels) Wacom Bamboo Sty- lus fineline (1024 levels) Wacom Intuos Cre- ative Stylus 2 (2048 levels)	Projected capaci- tive OR additional digitiser layer un- derneath display specifically de- signed for stylus input	Active stylus pen with in-built pressure sensor	Sensor type can be resis- tive (conductive polymer composite), capacitive, in- ductive or optical	Highly sensitive with many pressure levels, frequency used for artistic and draw- ing software	High pressure resolution (up to 2048 levels) Single sensor required Few constraints on sensor size and weight	Pressure sensing capability also dependent on device (controller, chip) and applications (software and drivers) Digitiser layer used in some devices adds to device thickness and weight Some styli may require charging or replace- ment batteries Expensive to replace if lost or broken
Resistive Touch- screen	Research or prototype only	Resistive	Resistive – con- ducting polymer composite	Percolative network of nanoparticles spanning 1– 10 µm transparent layer. 12 x 16 sensors across 3.5 inch touchscreen [51] Magnetically alugad	Detection of $0.04 - 1$ N force is reported	Current flow only when touchscreen is pressed – low power consumption Supports multi-touch input and in- put from any object Insensitive to electromagnetic noise	Additional layer may impact on optical transmission through touchscreen Particles may abrade with ITO electrodes leading to shorter product lifetime Resistive layer is prone to hysteresis effects
				magnetically aligned par- ticles spanning 50-100 μm transparent layer. Cur- rently patent only [56] Single layer of particles	Detection of up to 0.8 N		
				in 1–10 µm transparent laver [57]	force is reported		

#### <sup>983</sup> 5. Comparison of Pressure Sensing Touch Technologies and Future Trends

As a summary, Table 2 compares each technological application discussed in this paper in terms of its sensing mechanism, how the pressure–sensitivity is utilised, and the advantages and disadvantages of the technology in this particular application. whether the technology has already achieved commercial success and the relevant references to the literature.

It should be noted that a direct quantifiable comparison of these technologies is not possible as each is intended for a different application and as such may require different pressure sensing capabilities, different build parameters and different materials characteristics. However, a broad comparison in terms of the response parameter may prove useful in giving a general overview of the functionality that these technologies are capable of. We define the response parameter as

$$Response = \frac{X_i - X_{min}}{X_{max} - X_{min}} \times 100\%,\tag{6}$$

where  $X_i$  is the *i*th value of a measurable quantity X, for example resistance, capacitance or voltage, and  $X_{min}$  and  $X_{max}$  are the minimum and maximum values of X, respectively.

Fig.15 shows the response of the various types of pressure sensitive touch tech-998 nologies described in this review as a function of applied pressure. Response data 999 for Interlink FSR technology (FSR-Interlink), PyzoFlex® piezoelectric foil (PIEZO-1000 PyzoFlex), in-cell pressed capacitive touchscreens demonstrated by H. Kim and K. 1001 Kim (ICPC-K Kim and ICPC-H Kim) and the resistive pressure-sensitive touch-1002 screen patented by Peratech Ltd (RES-Peratech) are compared. For the FSR tech-1003 nology as described in Section 4.5.1, the Interlink sensor is chosen as a representative 1004 sample and for the resistive-pressure sensitive touchscreens outlined in section 4.2 1005 only the data for the Peratech touchscreen allows for the touch pressure to be calcu-1006 lated. 1007

Interestingly, the response for both RES-Peratech and FSR-Interlink technology is similar in that they operate over the same range of applied pressure. The response for both ICPC-K Kim and PIEZO-PyzoFlex ( $\mathbb{R}$ ) is almost linear in the range of pressures tested. Of course it is likely that for higher pressures the response would eventually saturate. The sensitivity of a particular sensor may be defined as the change in pressure (expressed as a percentage of the total pressure range of the sensor) required to produce a 50 % response:

$$Sensitivity = \frac{Pressure_{50\%} - Pressure_{0\%}}{Pressure_{100\%} - Pressure_{0\%}},\tag{7}$$



Figure 15: Comparison of sensor response to applied pressure for Interlink FSR technology (FSR-Interlink), PyzoFlex® piezoelectric foil (PIEZO-PyzoFlex), in-cell pressed capacitive touchscreens demonstrated by H. Kim and K. Kim (ICPC-K Kim and ICPC-H Kim) and the resistive pressure–sensitive touchscreen patented by Peratech Ltd (RES-Peratech).

where  $Pressure_{100\%} - Pressure_{0\%}$  defines the range of response, that is the dif-1015 ference between the maximum and minimum pressure (or force) able to be detected. 1016 The calculated sensitivity values are compared in Table 3. Here we can see the sen-1017 sitivity for both ICPC-K Kim and PIEZO-PyzoFlex(R) is around 50 %, indicating a 1018 linear response - 50 % of the sensor response is achieved through 50 % application 1019 of applied pressure. The other technologies have much lower sensitivity values. This 1020 indicates that the sensors are highly sensitive to low values of applied pressure, as 1021 only a pressure input typically less than 10% is required to produce a 50\% response. 1022 For each technology discussed in this review paper, the maximum and minimum 1023

force values from the available data (i.e. the range of response) are shown in Fig.16. 1024 The region corresponding to a light touch (0.1 N) and a hard press (10 N) is shaded. 1025 Both the pressure–sensing resistive touchscreen patented by Peratech Ltd and the 1026 FSR technology (in this case demonstrated by Interlink but in practice any of the 1027 sensors shown in Fig.12) produce a response for most forces in this range. Whilst the 1028 ICPC touchscreen demonstrated by K. Kim and the resistive touchscreen patented 1029 by Stantum are sensitive to smaller applied forces below this limit, in practice this 1030 is not particularly useful. 1031

Table 3: Sensitivity of selected pressure-sensing tactile technologies

Technology	Sensitivity
FSR-Interlink	1.5
PIEZO-PyzoFlex	45
ICPC-K Kim	59
ICPC-H Kim	8.2
<b>RES-Peratech</b>	5.8



Figure 16: Comparison of the range of forces to which the pressure–sensitive touch technologies described in this review exhibit a response. The force region comparable to a light touch (0.1 N) and a hard press (10 N) is shaded.

In terms of how pressure input may be utilised in computer interfaces, a pressure 1032 level may be defined as a range of pressures that will result in a certain reaction. 1033 For example in drawing software each pressure level would result in brush stroke 1034 of a certain diameter. The diameter would typically become larger for a higher 1035 pressure level input. A large sensitivity coupled with a small responsive pressure 1036 range means that the defined pressure levels must become narrow. The reaction 1037 becomes almost switch-like and access to intermediate pressure levels requires a high 1038 degree of user control. However for a smaller sensitivity coupled with a large range 1039 of response, broad pressure levels may be defined and it becomes easier for the user 1040 to manipulate between the pressure levels. 1041

<sup>1042</sup> Another important issue to consider is the cost of implementing the pressure–



Figure 17: An analysis of patent trends over time. A sample of 75 patents containing the words "force sensitive touchscreen" or "pressure sensitive touchscreen" were analysed. It was found that the majority of the patents described either a touchscreen which used discrete force sensors to measure both touch location and touch force, or a hybrid touchscreen where discrete force sensors were used alongside a location sensing technology, usually projected capacitive. Furthermore, the percentage of hybrid technologies is found to increase over time, whereas the percentage of discrete force-based technology patents decreases.

sensing solution. The addition of a small number of discrete pressure sensors, placed 1043 outside the touch module in strategic locations (for example force sensors placed in 1044 the four corners underneath the display) is likely to be a low-cost solution as the 1045 price of sourcing and incorporating the sensors into the build of the device should 1046 be comparatively low. Contrast this with incorporating the pressure sensor within 1047 the touchscreen itself – for example the continuous resistive films described in Sec-1048 tion 4.2 or even a 2D matrix array of sensors as described in Section 4.1.2. Here, the 1049 manufacture costs are likely to be high as new methods and additional steps must be 1050 included in the manufacture of the touchscreen. Whilst the resistive pressure sensing 1051 layers can be printed, using screen-print techniques for example, the manufacture of 1052 the pressed in-cell touchscreen uses photolithographic methods with a high number 1053 of manufacture steps. 1054

Analysis of the patent literature can yield information regarding the possible future successes for each technology. Fig.17 shows the patent trends in touch technolo-

gies since 1989. A patent search engine was used to search for patents containing the 1057 phrase "force sensing touchscreen" and/or "pressure sensing touchscreen". A sample 1058 size of 75 patents were analysed in the order they were listed on the search engine. 1059 It can be seen that the majority of the patents describe either force-based touch-1060 screens or the hybrid touchscreens described above. Interestingly, it can be seen 1061 that the percentage of purely force-based technology patents decreases over time, 1062 whereas the percentage of patents detailing the hybrid technology increases. In the 1063 category of 'other' the patents may describe resistive pressure sensing technology, 1064 FSRs and pressed–capacitive technology. This is perhaps of no surprise, as the lead-1065 ing touchscreen technologies currently use P-Cap or In-Cell P-Cap technology and 1066 hybridisation with discrete force sensors is perhaps the simplest compatible method 1067 of incorporating pressure sensitivity in such a device. 1068

# 1069 6. Conclusion

This review describes current and emerging tactile sensing technologies for use in HCI applications where touch pressure can provide a third dimension of user input. Pressure-sensing may be realised by the incorporation of resistive, piezoresistive, capacitive, piezoelectric or inductive pressure sensors.

Whilst some of the pressure–sensing technologies discussed are at present only de-1074 tailed in the patent literature, or available as prototype only, there are some products 1075 available on the market which already utilise pressure-sensitivity. These include the 1076 Microsoft Surface Touch Cover Keyboard and the Interlink VersaPad<sup>™</sup> laptop track-1077 pad, which contains FSR resistive pressure–sensing technology. Pressure sensitivity is 1078 also being developed for transparent touchscreens, for example by the incorporation 1079 of a resistive pressure-sensing layer in a resistive-type touchscreen, or by a capacitive 1080 pressure sensing array in a pressed 'in-cell' touchscreen. However, currently these 1081 technologies are in the research stage only, and whilst at least the resistive solution 1082 is under development by some companies there is currently no device on the market 1083 utilising this technology. The pressed in-cell approach has been studied by various 1084 research groups, for its potential applicability in touchscreens. However, the inherent 1085 disadvantages of this technology mean it is unlikely to be commercialised in the near 1086 future. 1087

Perhaps the most success (in terms of number of patents and devices which utilise this principle) has been achieved by the addition of discrete pressure sensors outside the touch module, where the sensors do not need to be transparent. For example, the Apple Watch uses this method to distinguish between a light touch and a hard press, and the ForcePad<sup>™</sup> trackpad produced by Synaptics, Inc. can detect 64 levels <sup>1093</sup> of applied pressure from five fingers simultaneously. Perhaps the main benefit of this <sup>1094</sup> approach is that the specific advantages of the touchscreen can be kept, for example <sup>1095</sup> the multi-touch functionality associated with P-Cap touchscreens, as the pressure <sup>1096</sup> sensors can be integrated underneath any display using any location–sensing inter-<sup>1097</sup> face. Analysis of patent trends show this approach is rapidly gaining traction. For <sup>1098</sup> these reasons, the authors believe that this approach may show the most commercial <sup>1099</sup> successes in the next few years.

In the words of Apple "[Pressure sensing] is the most significant new sensing capability since Multi-Touch" [106]. Their recent focus on force-sensing in laptop trackpads and wearable technology such as the Apple Watch show that it is only a matter of time before pressure input becomes mainstream in the new generation of human-computer interfaces.

# 1105 7. Acknowledgements

The authors would like to acknowledge the Technology Strategy Board (TSB), the Knowledge Transfer Partnership scheme, and the Faculty of Science at Durham University for funding this research.

1109 8. Figures

#### 1110 References

- [1] S. A. Brewster, M. Hughes, Pressure-based text entry for mobile devices,
   in: Proceedings of the 11th International Conference on Human-Computer
   Interaction with Mobile Devices and Services, ACM, p. 9.
- [2] G. Wilson, C. Stewart, S. A. Brewster, Pressure-based menu selection for mobile devices, in: Proceedings of the 12th international conference on Human computer interaction with mobile devices and services, ACM, pp. 181–190.
- [3] K. Zhang, K. Douros, H. Li, H. Li, Y. Wei, Systems and methods for pressurebased authentication of an input on a touch screen, 2011 Mar 3. US Patent App. 12/548,983.
- [4] E. Backlund, H. Bengtsson, H. Heringslack, J. Sassi, O. Thörn, P. Åberg, User interface with three dimensional user input, 2014 Jan 7. US Patent 8,625,882.
- [5] S. Heo, G. Lee, Force gestures: Augmenting touch screen gestures with normal and tangential forces, in: Proceedings of the 24th annual ACM symposium on User interface software and technology, ACM, pp. 621–626.

[6] S.-J. Woo, J.-H. Kong, D.-G. Kim, J.-M. Kim, A thin all-elastomeric capacitive pressure sensor array based on micro-contact printed elastic conductors, 1126 Journal of Materials Chemistry C 2 (2014) 4415–4422. 1127 [7] M. Ramuz, B. C.-K. Tee, J. B.-H. Tok, Z. Bao, Transparent, optical, pressure-1128 sensitive artificial skin for large-area stretchable electronics, Advanced Mate-1129 rials 24 (2012) 3223–3227. 1130 [8] A. Diaz Lantada, C. González Bris, P. Lafont Morgado, J. Sanz Maudes, Novel 1131 system for bite-force sensing and monitoring based on magnetic near field com-1132 munication, Sensors 12 (2012) 11544–11558. 1133 [9] W. Tao, T. Liu, R. Zheng, H. Feng, Gait analysis using wearable sensors, 1134 Sensors 12 (2012) 2255–2283. 1135 [10] R. Dahiya, G. Metta, M. Valle, G. Sandini, Tactile sensing; from humans to 1136 humanoids, IEEE Transactions on Robotics 26 (2010) 1–20. 1137 [11] M. L. Hammock, A. Chortos, B. C.-K. Tee, J. B.-H. Tok, Z. Bao, 25th anniver-1138 sary article: The evolution of electronic skin (e-skin): A brief history, design 1139 considerations, and recent progress, Advanced Materials 25 (2013) 5997–6038. 1140 [12] T. Someya, T. Sekitani, Printed skin-like large-area flexible sensors and ac-1141 tuators, Procedia Chemistry 1 (2009) 9 - 12. Proceedings of the Eurosensors 1142 {XXIII} conference. 1143 [13] H. Yousef, M. Boukallel, K. Althoefer, Tactile sensing for dexterous in-hand 1144 manipulation in robotics-a review, Sensors and Actuators A: Physical 167 1145 (2011) 171–187. 1146 [14] M. I. Tiwana, S. J. Redmond, N. H. Lovell, A review of tactile sensing tech-1147 nologies with applications in biomedical engineering, Sensors and Actuators 1148 A: Physical 179 (2012) 17–31. 1149 [15] G. Walker, A review of technologies for sensing contact location on the surface 1150 of a display, Journal of the Society for Information Display 20 (2012) 413–440. 1151 [16] R. Phares, M. Fihn, Handbook of Visual Display Technology, Springer, pp. 1152 935 - 974.1153 [17] G. Barrett, R. Omote, Projected-capacitive touch technology, Information 1154 Display 26 (2010) 16–21. 1155

1125

- [18] G. Walker, Interactive Displays: Natural Human-Interface Technologies, John
   Wiley & Sons, pp. 27–106.
- [19] G. Walker, Display week 2013 review: Touch tech-1158 2013. [Magazine Article] Available online nology, at 1159 http://informationdisplay.org/IDArchive/2013/SeptemberOctober/Touch.aspx, 1160 accessed Sep. 14. 1161
- <sup>1162</sup> [20] A. K. Bhowmik, Advances in interactive display technologies, Journal of the <sup>1163</sup> Society for Information Display 20 (2012) 409–412.
- [21] W. Buxton, Multi-touch systems I have known and loved, 2007. Available
  online at http://www.billbuxton.com/multitouchOverview.html, accessed Sep.
  14.
- [22] A. Erol, G. Bebis, M. Nicolescu, R. D. Boyle, X. Twombly, Vision-based hand
   pose estimation: A review, Computer Vision and Image Understanding 108
   (2007) 52–73.
- [23] D. Bloor, K. Donnelly, P. Hands, P. Laughlin, D. Lussey, A metal-polymer
  composite with unusual properties, Journal of Physics D: Applied Physics 38
  (2005) 2851.
- [24] D. Bloor, A. Graham, E. Williams, P. Laughlin, D. Lussey, Metal-polymer
  composite with nanostructured filler particles and amplified physical properties, Applied physics letters 88 (2006) 102103.
- 1176 [25] A. Daz-Lantada, P. Lafont, J. Sanz, J. Munoz-Guijosa, J. Otero, "quantum 1177 tunnelling composites: Characterisation and modelling to promote their appli-1178 cations as sensors", "Sensors and Actuators A: Physical" 164 (2010) 46–57.
- [26] C. D. Pina, E. Zappa, G. Busca, A. Sironi, E. Falletta, "electromechanical properties of polyanilines prepared by two different approaches and their applicability in force measurements", "Sensors and Actuators B: Chemical" 201 (2014) 395–401.
- [27] L. Pan, A. Chortos, G. Yu, Y. Wang, S. Isaacson, R. Allen, Y. Shi,
  R. Dauskardt, Z. Bao, An ultra-sensitive resistive pressure sensor based on
  hollow-sphere microstructure induced elasticity in conducting polymer film,
  Nature communications 5 (2014).

- [28] S. Khan, R. Dahiya, L. Lorenzelli, Technologies for printing sensors and electronics over large flexible substrates: A review, Sensors Journal, IEEE PP (2014) 1–1.
- [29] E. Pritchard, M. Mahfouz, B. Evans, S. Eliza, M. Haider, Flexible capacitive sensors for high resolution pressure measurement, in: Sensors, 2008 IEEE, IEEE, pp. 1484–1487.
- [30] A. Decharat, S. Wagle, F. Melandsø, Effect of polymer electrode thickness on
  the acoustical properties of all-screen printed piezoelectric PVDF copolymer
  transducers, Japanese Journal of Applied Physics 53 (2014) 05HB16.
- <sup>1196</sup> [31] A. Shirinov, W. Schomburg, Pressure sensor from a PVDF film, Sensors and <sup>1197</sup> Actuators A: Physical 142 (2008) 48–55.
- [32] T. Julien, Flexo-printed piezoelectric PVDF pressure sensors, 2012. Masters
   Thesis, Department of Chemistry, Tampere University of Technology, Tampere,
   Finland.
- [33] J.-S. Heo, J.-Y. Kim, J.-J. Lee, Tactile sensors using the distributed optical
  fiber sensors, in: Sensing Technology, 2008. ICST 2008. 3rd International
  Conference on, pp. 486–490.
- [34] R. Miller, S. Bisset, T. Allen, G. Steinbach, Object position detector, 1994. US
   Patent 5,374,787.
- [35] R. Rao, P. Tilley, A. Tungare, Y. Wei, Device and method for automated use of force sensing touch panels, 2013 Nov 21. US Patent App. 13/038,235.
- [36] S. Vadagave, S. Vojjala, H. El-Khoury, User interface with child-lock feature,
   2014 Jun 26. WO Patent App. PCT/US2013/070,333.
- <sup>1210</sup> [37] G. Walker, M. Fihn, LCD in-cell touch, Information Display 27 (2010) 8–14.
- <sup>1211</sup> [38] H.-K. Kim, S. Lee, K.-S. Yun, Capacitive tactile sensor array for touch screen <sup>1212</sup> application, Sensors and Actuators A: Physical 165 (2011) 2–7.
- [39] H.-K. Kim, S.-G. Lee, J.-E. Han, T.-R. Kim, S.-U. Hwang, S. D. Ahn, I.-K. You,
  K.-I. Cho, T.-K. Song, K.-S. Yun, Transparent and flexible tactile sensor for
  multi touch screen application with force sensing, in: Solid-State Sensors, Actuators and Microsystems Conference, 2009. Transducers 2009. International,
  pp. 1146–1149.

- [40] K. Kim, K. Shin, J.-H. Han, K.-R. Lee, W.-H. Kim, K.-B. Park, B.-K. Ju,
  J. Pak, Deformable single wall carbon nanotube electrode for transparent tactile touch screen, Electronics Letters 47 (2011) 118–120.
- [41] C. Brown, K. Kida, S. Yamagishi, H. Kato, 24.3 l: Late-news paper: In-cell capacitance touch-panel with improved sensitivity, in: SID Symposium Digest of Technical Papers, volume 41, Wiley Online Library, pp. 346–349.
- [42] C.-S. Kim, B. K. Kang, J. H. Jung, M. J. Lee, H. B. Kim, S. S. Oh, S. H.
  Jang, H. J. Lee, H. Kastuyoshi, J. K. Shin, Active matrix touch sensor perceiving liquid crystal capacitance with amorphous silicon thin film transistors,
  Japanese Journal of Applied Physics 49 (2010) 03CC03.
- [43] C.-Y. Huang, L. Lou, A. J. Danner, C. Lee, Transparent force sensing arrays
   with low power consumption using liquid crystal arrays, Sensors and Actuators
   A: Physical 190 (2013) 136–140.
- [44] T.-Y. Chen, Y.-C. Wang, R. Chen, C.-Y. Lo, P-219L: Late-News Poster: Simultaneous Normal and Shear Force Sensor for Flexible and Transparent Display
   Applications, in: SID Symposium Digest of Technical Papers, volume 42, pp. 1862–1865.
- [45] P. Kallassi, B. Mackey, L. Hsieh, Device and method for localized force sensing,
   2014 Sep 4. US Patent App. 13/838,003.
- [46] A. Jamshidi-Roudbari, S. Chang, C. Yu, T. Chang, Display integrated pressure
   sensor, 2014 Sep 4. US Patent App. 13/784,509.
- [47] O. Leung, J. Harley, J. Wright, C. Leong, K. Babiarz, Force sensing using
  dual-layer cover glass with gel adhesive and capacitive sensing, 2014 Mar 27.
  US Patent App. 13/624,855.
- 1242 [48] Samsung, User Manual TL220 v1.2, 2009. [User Manual] Available online: 1243 http://www.samsung.com/us/support/owners/product/EC-TL220ZBPRUS.
- <sup>1244</sup> [49] G. Largillier, Developing the first commercial product that uses multi-touch <sup>1245</sup> technology, Information Display 23 (2007) 14.
- [50] D. R. Cairns, G. P. Crawford, A. F. Chernefsky, P-7: Wear resistance of indium tin oxide coatings on polyethylene terephthalate substrates for touchscreen applications, SID Symposium Digest of Technical Papers 32 (2001) 574–577.

- [51] H. Li, P. Maniar, Y. Wei, Transparent force sensor and method of fabrication,
   2013 Jan 31. US Patent App. 12/725,699.
- [52] H. Li, Y. Wei, H. Li, S. Young, D. Convey, J. Lewis, P. Maniar, Late-news
  paper: Multitouch pixilated force sensing touch screen, Proc. SID Tech. Dig
  (2009) 455–458.
- [53] P. M. H. Li, Y. Wei, Transparent pressure sensor and method for using, 2009
   Sep 24. US Patent App. 12/052,365.
- Iz56 [54] J. Leng, W. Huang, X. Lan, Y. Liu, S. Du, Significantly reducing electrical
   resistivity by forming conductive Ni chains in a polyurethane shape-memory
   polymer/carbon-black composite, Applied Physics Letters 92 (2008) 204101.
- [55] X.-L. Xie, Y.-W. Mai, X.-P. Zhou, Dispersion and alignment of carbon nanotubes in polymer matrix: A review, Materials Science and Engineering R:
  Reports 49 (2005) 89–112.
- [56] G. Goncalves, L. Hirsch, P. Joguet, J. Olivier, G. Wantz, Method for the
  production of a transparent film, in particular for a transparent array-type
  tactile sensor, 2012 Sep 13. WO Patent App. 12/050,439.
- <sup>1265</sup> [57] R. Divigalpitiya, P. Chen, D. Kanno, G. Miholics, V. Patel, M. Scholz, Force <sup>1266</sup> sensing membrane, 2007 Aug 28. US Patent 7,260,999.
- [58] R. Divigalpitiya, D. Livingstone, R. Moshrefzadeh, E. Cross, Pressure activated
   switch and touch panel, 2004 Oct 26. US Patent 6,809,280.
- [59] S. Bae, H. Kim, Y. Lee, X. Xu, J.-S. Park, Y. Zheng, J. Balakrishnan, T. Lei,
  H. R. Kim, Y. I. Song, et al., Roll-to-roll production of 30-inch graphene films for transparent electrodes, Nature Nanotechnology 5 (2010) 574–578.
- <sup>1272</sup> [60] J.-Y. Lee, S. T. Connor, Y. Cui, P. Peumans, Solution-processed metal <sup>1273</sup> nanowire mesh transparent electrodes, Nano Letters 8 (2008) 689–692.
- [61] D. S. Hecht, D. Thomas, L. Hu, C. Ladous, T. Lam, Y. Park, G. Irvin,
  P. Drzaic, Carbon-nanotube film on plastic as transparent electrode for resistive touch screens, Journal of the Society for Information Display 17 (2009)
  941–946.
- [62] C. Lussey, P. Laughlin, A. Graham, D. Bloor, D. Lussey, Pressure sensitive polymer composite material adapted for touch screen, 2013 Mar 7. US Patent App. 14/007,232.

- <sup>1281</sup> [63] D. Lussey, A. King, C. Lussey, Polymer composition, 2002 Dec 17. US Patent <sup>1282</sup> 6,495,069.
- [64] T. Suzuki, Y. Kai, Y. Endo, Y. Takai, J. Shimizu, Y. Yamaoka, S. Okumura,
  S. Hirai, Y. Imai, Touch panel having press detection function and pressure
  sensitive sensor for the touch panel, 2012 Jan 10. US Patent 8,094,134.
- [65] G. Walker, Stantums Newest Digital-Resistive Touch-Panel, 2012. [Press Release] Available online at http://idmagazinedisplayweek2012.blogspot.co.uk/, accessed Dec. 14.
- [66] Elo Touch Solutions. Inc., Acoustic Pulse Recogni-1289 Technology, "Accessed 2015". Website tion Touch March 1290 http://www.elotouch.com/Technologies/AcousticPulseRecognition. 1291
- [67] 3M Innovative Properties Company, Dispersive Sig-1292 nal Technology, Accessed March 2015.Website 1293 http://solutions.3m.co.uk/wps/portal/3M/en\_GB/TouchScreens/Home/ProdInfo/ScreenTech/I 1294
- [68] Elo Touch Solutions, Inc., Intellitouch(R) surface acous-1295 tic touch solutions. Accessed Mar 2015.Website wave 1296 http://www.elotouch.com/technologies/intellitouch/default.asp. 1297
- <sup>1298</sup> [69] D. A. Soss, Advances in force-based touch panels, Information Display 23 <sup>1299</sup> (2007) 20.
- <sup>1300</sup> [70] [Magazine Article], IBM relaunches the Touch Display, this time for Multime-<sup>1301</sup> dia, PC Magazine 10 (1991) 38.
- [71] [Magazine Article], TouchSelect turns ordinary monitors into touch-screens,
   PC Magazine 10 (1991) 42.
- Image: Interpretation of the second se
- [73] A. Mölne, Integrated pressure sensitive lens assembly, 2012 Sep 18. US Patent
   8,269,731.
- [74] D. Brown, C. Brown, A. Mölne, Integrated feature for friction less movement
   of force sensitive touch screen, 2012 Mar 27. US Patent 8,144,453.

- [75] NextInput, Completes Inc., NextInput Next Iteration of Force-1310 Sensor, 2012 Nov 14. [Press Release] Available online Touch at 1311 http://www.nextinput.com/news accessed Dec 14. 1312
- [76] J. Bernstein, A. Cieplinski, B. Degner, D. Kerr, P. Kessler, P. Puskarich,
  M. Coelho, A. Pance, Touch pad with force sensors and actuator feedback,
  2014 Jan 21. US Patent 8,633,916.
- [77] N. Parivar, W. Westerman, Gesture and touch input detection through force
   sensing, 2014 Jan 30. US Patent 8,633,916.
- [78] Apple Inc., Apple unveils Apple Watch–Apples most personal device ever, 2014.
  [Press Release] Available online at https://www.apple.com/uk/pr/, accessed
  Dec 14.
- [79] Y. Fukushima, Annular plate shape; variable resistor of conductive rubber;
  push and thrust type writing unit, 1997. US Patent 5,633,471.
- [80] Z. Zeliff, Y. Li, K. Perpich, Y. Huang, K. Lu, Stylus with pressure sensor, 2013.
  US Patent App. 13/909,479.
- [81] Y. Stern, R. Zachut, Y. Tzafrir, E. Mann, O. Tamir, A. Kalmanovich, Pressure sensitive stylus for a digitizer, 2013. US Patent 8,536,471.
- [82] F. Lu, P. Wu, Z. He, R. You, C. Pan, Stylus and capacitive pressure sensing
  element employed therein, 2014. US Patent App. 13/654,627.
- [83] F. Fado, T. Wong, G. Verrier, R. Donaldson, P. Kowalewski, Digitizing stylus having capacitive pressure and contact sensing capabilities, 1995. US Patent 5,438,275.
- [84] A. Fergusson, C. Mercea, Apparatus to sense stylus nib pressures, 2014. EP
   Patent App. EP20,130,159,122.
- [85] F. N. Eventoff, Electronic pressure sensitive transducer apparatus, 1982 Feb 2.
  U.S. Patent 4,314,227.
- [86] S. Yaniger, Stannous oxide force transducer and composition, 1994 Mar 22.
  U.S. Patent 5,296,837.
- [87] B. Krivopal, Pressure sensitive ink means, and methods of use, 1999 Nov 23.
  U.S. Patent 5,989,700.

- [88] M. A. Graham, D. Lussey, Resistance changing sensor, 2012 Mar 29. US Patent
   App. 13/247,082.
- [89] A. J. Webb, M. Szablewski, D. Bloor, D. Atkinson, A. Graham, P. Laughlin,
  D. Lussey, A multi-component nanocomposite screen-printed ink with nonlinear touch sensitive electrical conductivity, Nanotechnology 24 (2013) 165501.
- [90] Digi-Key Corporation, Available to buy online at www.digikey.co.uk, Accessed
   March 2015.
- [91] Sensitronics LLC, Available to buy online at www.sensitronics.com, Accessed
   March 2015.
- [92] S. Yaniger, Force sensing resistors: A review of the technology, in: Electro
   International, 1991, pp. 666–668.
- [93] N. Rana, Application of force sensing resistor (FSR) in design of pressure scanning system for plantar pressure measurement, in: Second international conference on Computer and Electrical Engineering, 2009 (ICCEE'09), volume 2, pp. 678–685.
- [94] B. Choi, H. R. Choi, S. Kang, Development of tactile sensor for detecting
  contact force and slip, in: IEEE/RSJ International Conference on Intelligent
  Robots and Systems, 2005 (IROS 2005), pp. 2638–2643.
- [95] E. R. Miranda, M. M. Wanderley, New digital musical instruments: control and interaction beyond the keyboard, volume 21 of *The Computer Music and Digital Audio Series*, AR Editions, Inc., pp. 109–152.
- <sup>1361</sup> [96] C. Ashruf, Thin flexible pressure sensors, Sensor Review 22 (2002) 322–327.
- [97] A. Hollinger, M. M. Wanderley, Evaluation of commercial force-sensing resistors, in: Proceedings of International Conference on New Interfaces for Musical Expression, 2006.
- [98] C. Lebossé, P. Renaud, B. Bayle, M. de Mathelin, Modeling and evaluation of
  low-cost force sensors, IEEE Transactions on Robotics 27 (2011) 815–822.
- I. D. Rosenberg, A. Grau, C. Hendee, N. Awad, K. Perlin, IMPAD: an inexpensive multi-touchpressure acquisition device, in: CHI'09 Extended Abstracts on Human Factors in Computing Systems, ACM, pp. 3217–3222.

- <sup>1370</sup> [100] S. N. Bathiche, Computer keyboard with quantitatively force-sensing keys, <sup>1371</sup> 2007 Aug 14. US Patent 7,256,768.
- [101] C. Rendl, P. Greindl, M. Haller, M. Zirkl, B. Stadlober, P. Hartmann, PyzoFlex: Printed piezoelectric pressure sensing foil, in: Proceedings of the 25th annual ACM symposium on user interface software and technology, ACM, pp. 509–518.
- [102] M. Zirkl, G. Scheipl, B. Stadlober, P. Hartmann, M. Haller, C. Rendl,
  P. Greindl, PyzoFlex: A printed piezoelectric pressure sensing foil for human
  machine interfaces, in: SPIE Organic Photonics & Electronics, International
  Society for Optics and Photonics, pp. 883124–883124.
- <sup>1380</sup> [103] R. Schediwy, K. Inscore, Force sensing input device and method for determining <sup>1381</sup> force information, 2014 Jan 21. US Patent 8,633,911.
- <sup>1382</sup> [104] J. Wang, R. W. Lindeman, ForceExtension: Extending isotonic position-<sup>1383</sup> controlled multi-touch gestures with rate-controlled force sensing for 3D ma-<sup>1384</sup> nipulation, in: 2013 IEEE Symposium on 3D User Interfaces (3DUI), pp. 3–6.
- [105] C. Rendl, P. Greindl, K. Probst, M. Behrens, M. Haller, Presstures: exploring pressure-sensitive multi-touch gestures on trackpads, in: Proceedings of the 32nd annual ACM conference on Human factors in computing systems, ACM, pp. 431–434.
- <sup>1389</sup> [106] Apple, Inc., Innovation in Every Interaction, Accessed March 2015. Available <sup>1390</sup> online at http://www.apple.com/watch/technology.